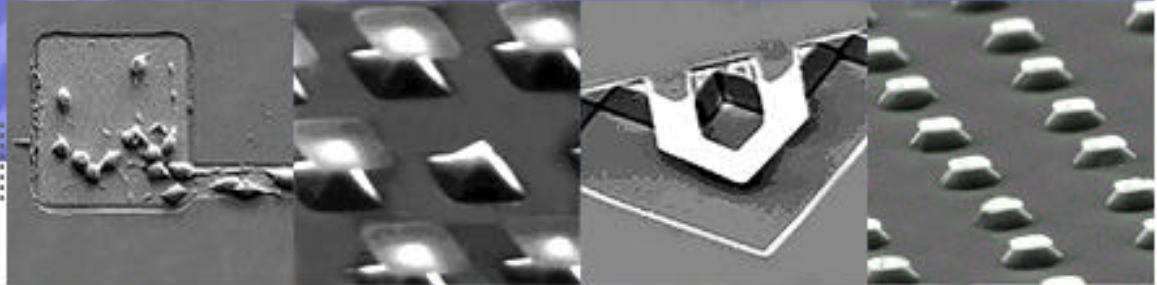


LIBNA is focused on research in BioMEMS & Bionanotechnology, in the areas of interface between micro, nanoengineering & life sciences



# Introduction to BioMEMS & Bionanotechnology

## Lecture 3

**R. Bashir**

**Laboratory of Integrated Biomedical Micro/Nanotechnology and Applications (LIBNA), Discovery Park**

**School of Electrical and Computer Engineering,**

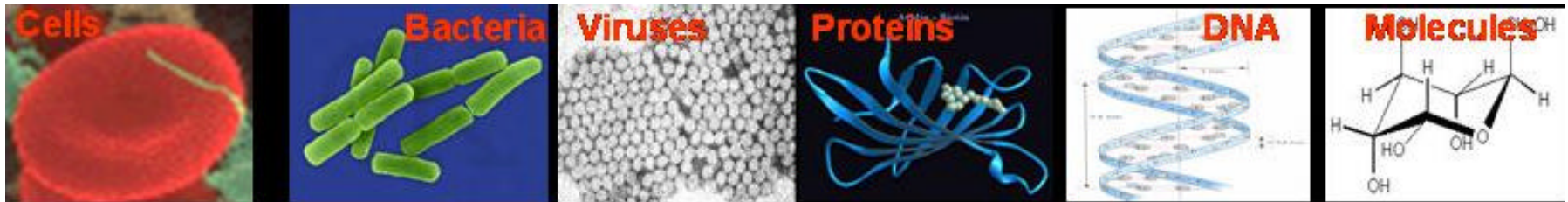
**Weldon School of Biomedical Engineering,**

**Purdue University, West Lafayette, Indiana**

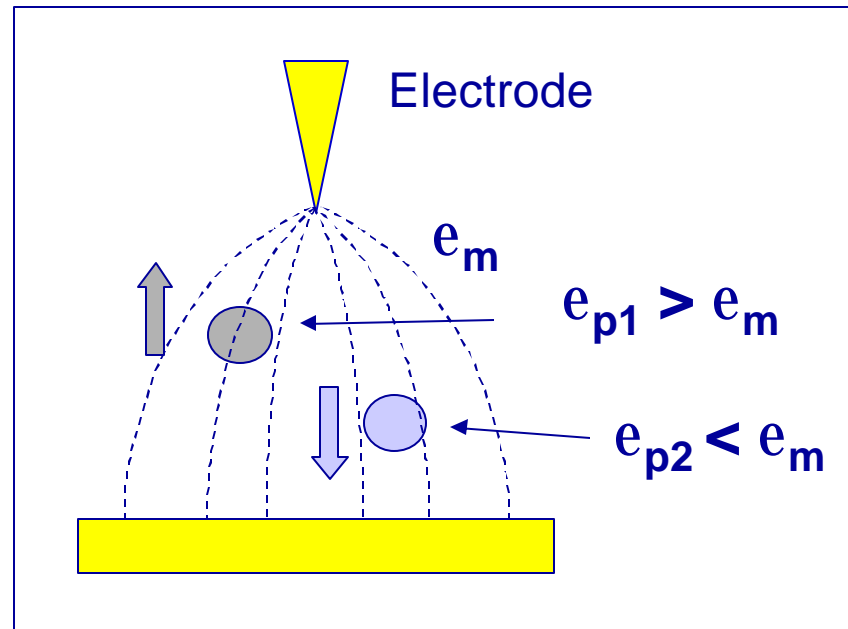
**<http://engineering.purdue.edu/LIBNA>**

# Key Topics

- Biochips/Biosensors and Device Fabrication
- Cells, DNA, Proteins
- Micro-fluidics
- Biochip Sensors & Detection Methods
- Micro-arrays
- Lab-on-a-chip Devices



# Dielectrophoresis

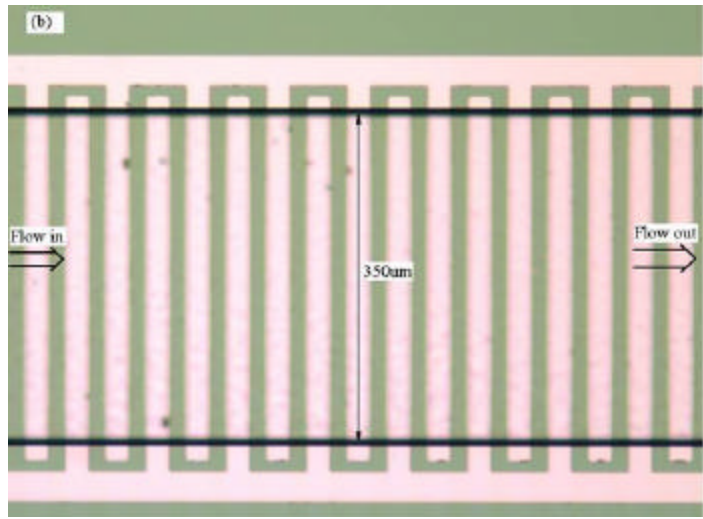


**Simplest approximation:**

$$F = 2pe_0 e_m r^3 \operatorname{Re}[f_{CM}] \nabla |E_{RMS}|^2$$

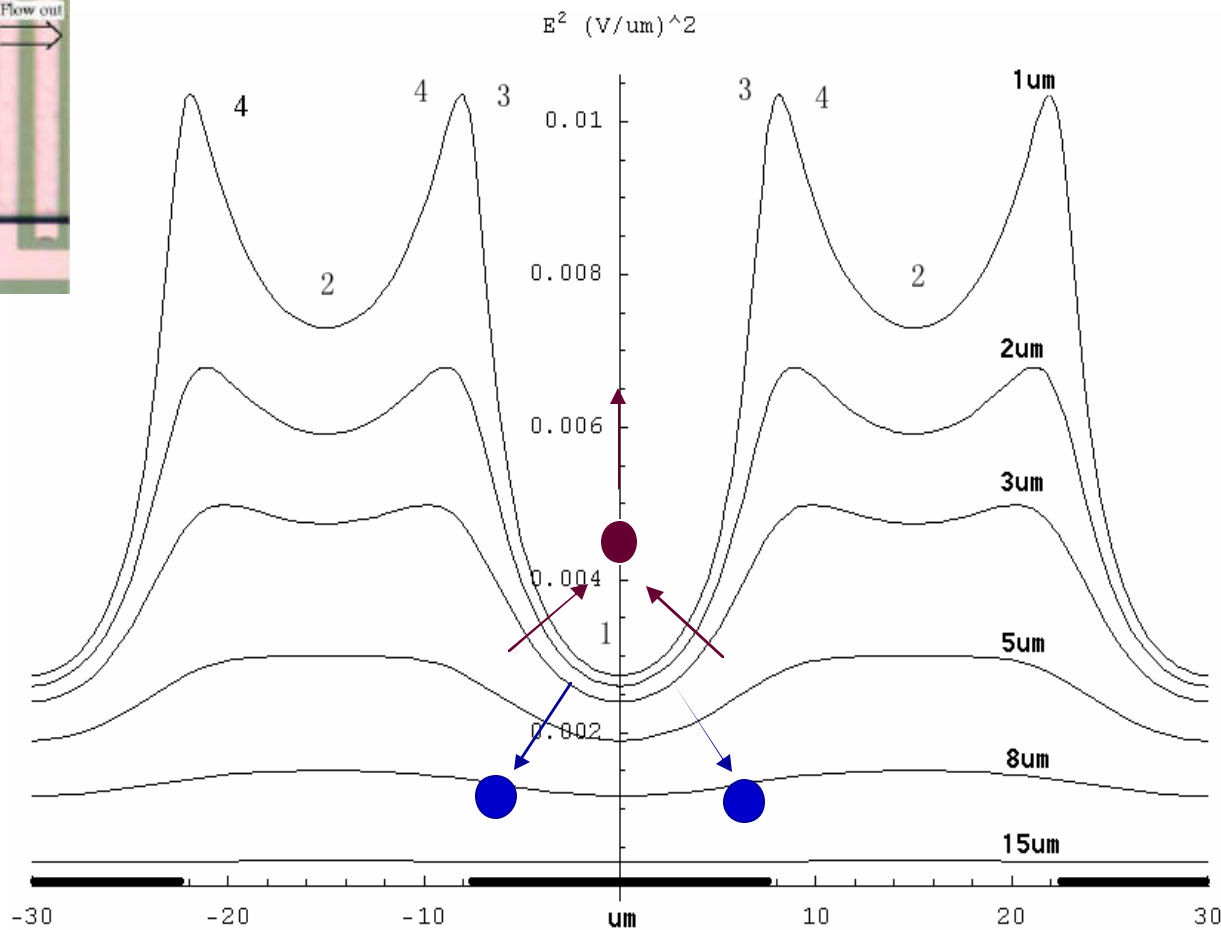
$$f_{CM}(e_p, e_m) = \frac{e_p - e_m}{e_p + 2e_m} \quad \epsilon_p = \epsilon(\omega)$$

# Dielectrophoresis on Interdigitated Electrodes

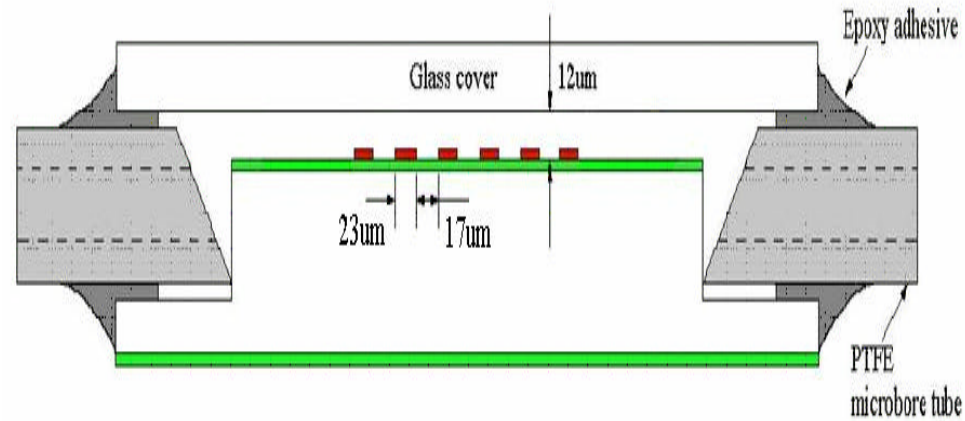
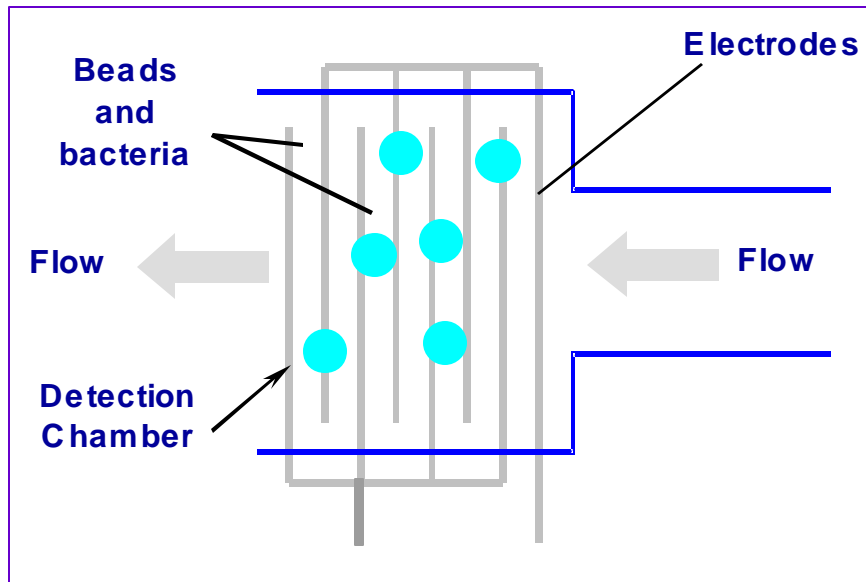


Interdigitated electrodes on a chip

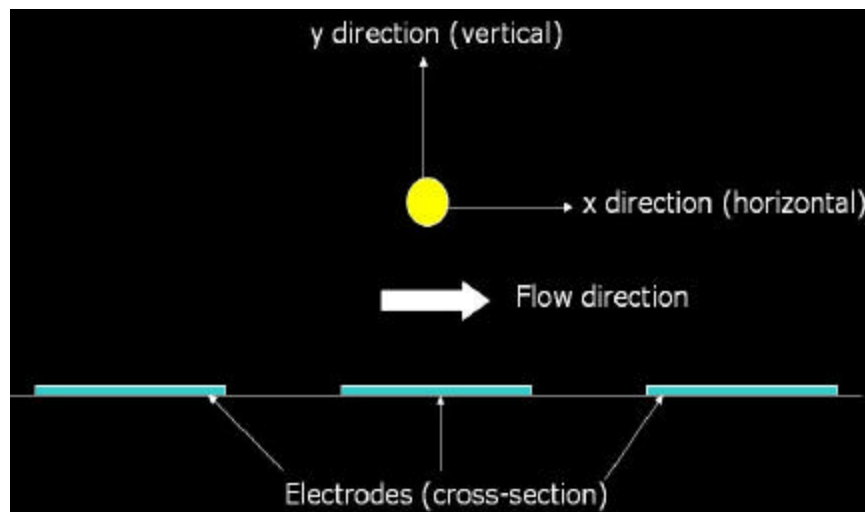
Polystyrene beads :  $e_p < e_m \rightarrow$  negative DEP  
 Cells :  $e_p < e_m \rightarrow$  Negative DEP  
 Cells :  $e_p > e_m \rightarrow$  Positive DEP



# A Dielectrophoretic Filter



**Schematic of the device cross-section**



# Forces on a particle in a micro-fluidic flow

- 1. DEP Force
- 2. Sedimentation Force

$$F_{sedi} = \frac{4}{3} \rho R^3 (\mathbf{r}_p - \mathbf{r}_m) g$$

- 3. Hydrodynamic Drag Force:

$$F_{HD-drag} \approx 6pkRh(\mathbf{u}_m - \mathbf{u}_p)$$

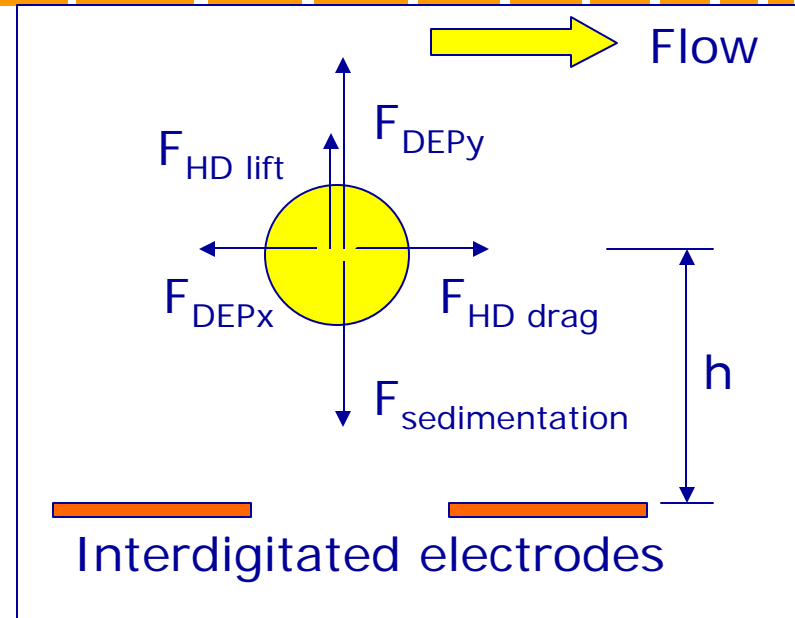
- Assume a parabolic laminar flow profile:

$$\mathbf{u} = 6\langle \mathbf{u} \rangle \frac{x}{h} \left( 1 - \frac{x}{h} \right) \quad \langle \mathbf{u} \rangle = \frac{U}{wh}$$

U: flow rate in  $\mu\text{l}/\text{min}$

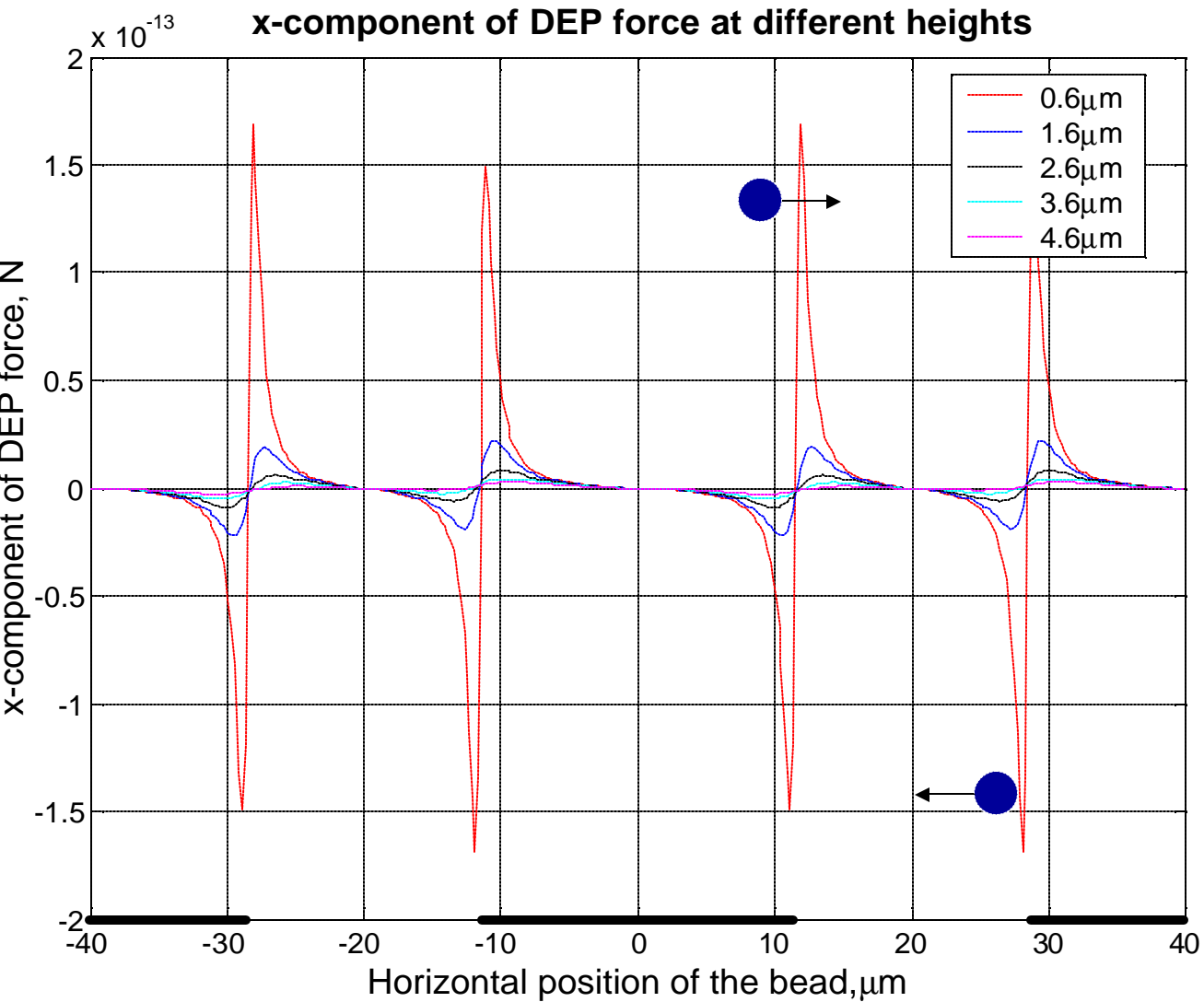
- 4. Hydrodynamic lifting force

$$F_{HD-lift} \approx 0.153R^2h \frac{1}{(x-R)} \cdot \frac{d\mathbf{u}_m}{dx} \Big|_{x=0}$$



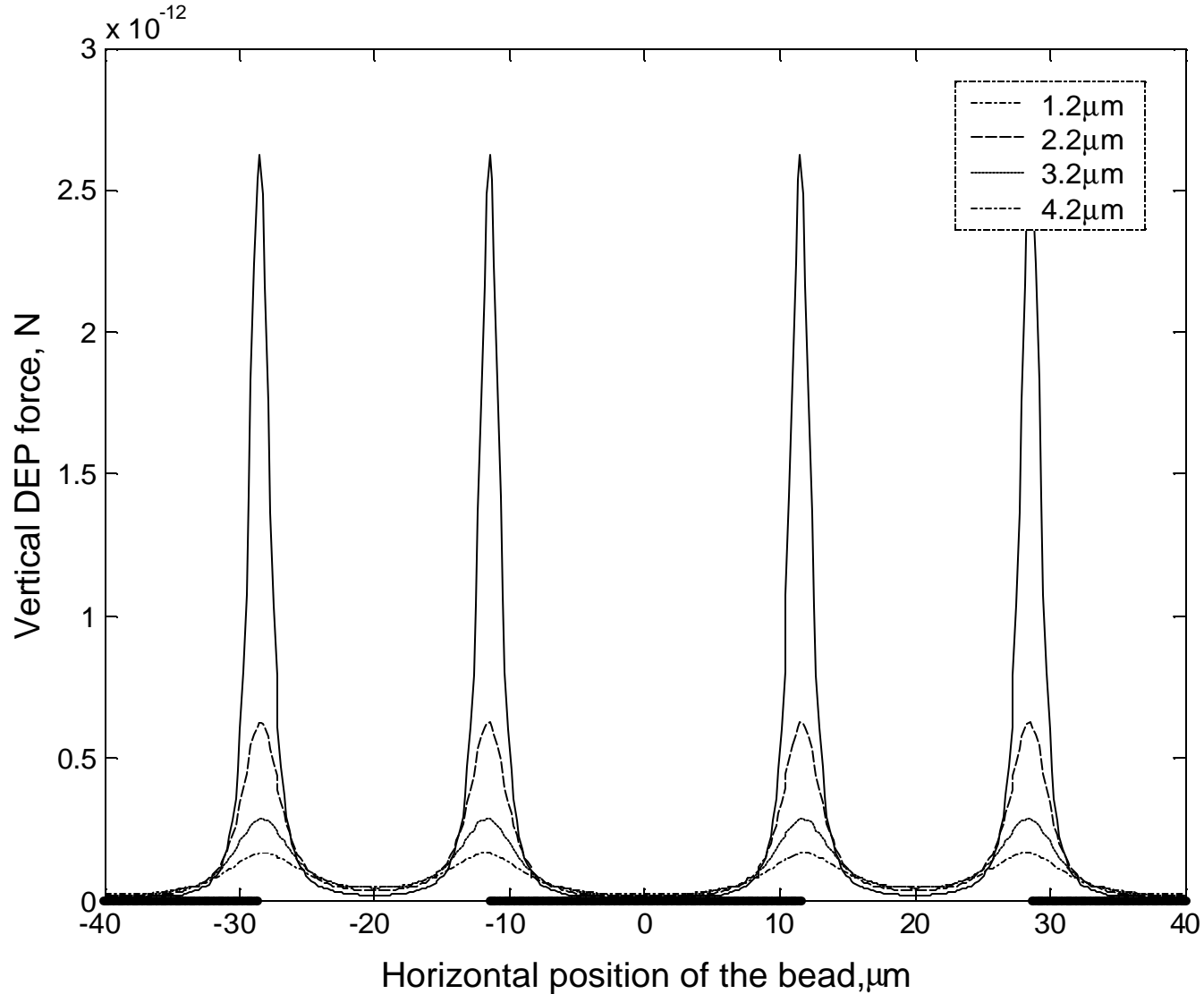
- Two orders of magnitude smaller than typical DEP lifting force
- Neglected here

# X-component of DEP force at different heights



- **Bead diameter:** 0.7mm
- **Bead conductivity:**  $2e-4$  S/m
- **Relative permittivity of bead:** 2.6
- **Bead density:** 1.05 g/cm<sup>3</sup>
- **Medium (DI water) conductivity:** 2.5 S/m
- **Relative permittivity of medium:** 80
- **Medium density:** 1.0 g/cm<sup>3</sup>
- **Voltage:** 1Vrms
- **Frequency:** 580KHz

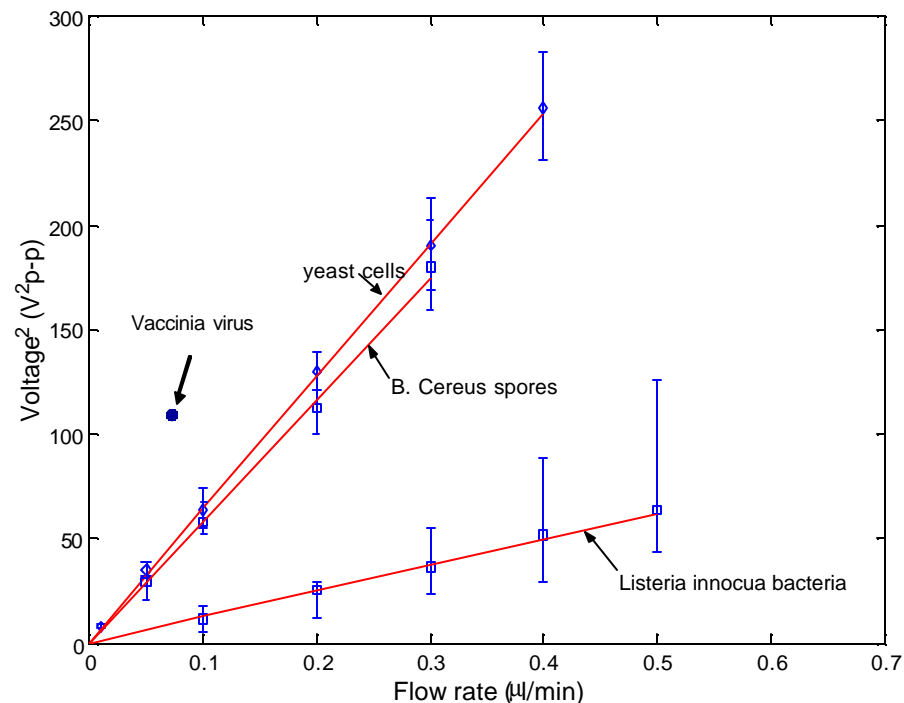
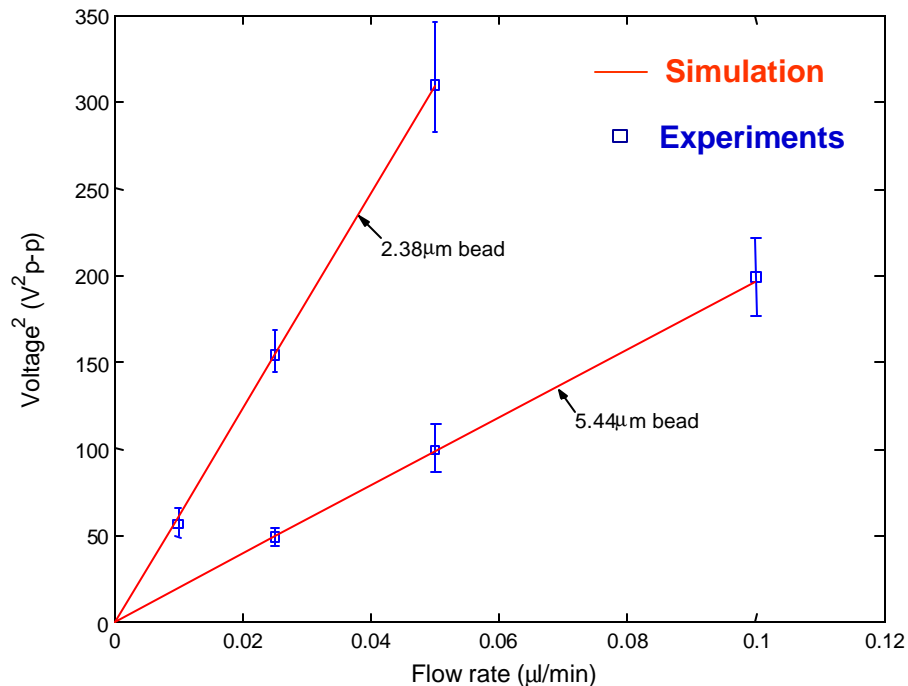
# Y-component of DEP force at different heights





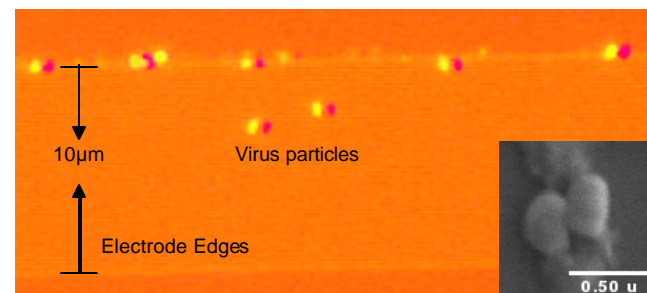
# Trapping of beads (- DEP) and microorganisms (+ DEP)

Plot of holding voltage of the negative DEP traps on interdigitated electrodes versus flow rate for polystyrene beads with different diameters in DI water (conductivity  $\sim 1 \mu\text{S/cm}$ ) at 1 MHz

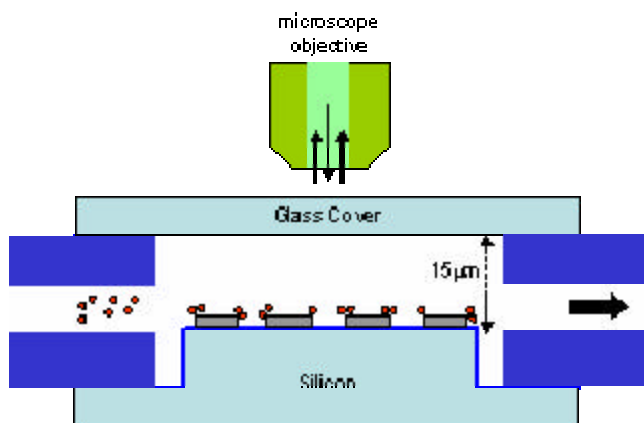


# Dielectrophoretic Trapping of *Vaccinia* virus (positive DEP)

- Fluorescent imaging of nano-scale virus particles (*Vaccinia* virus and Human Corona Virus)
- Trapping of viruses in DEP filters
- Dual labeling of viruses with fluorescent dyes

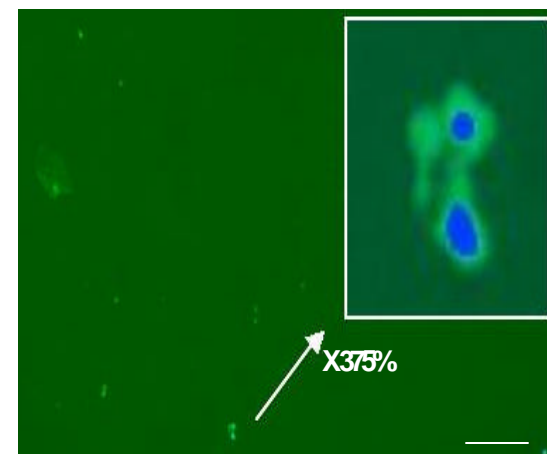
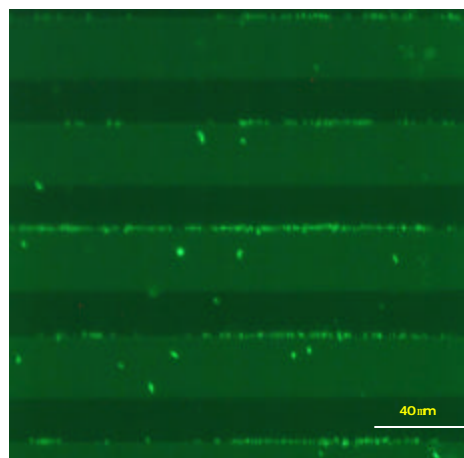


The dual (DiOC63, green and DiI, red) labelled viral particles



Virus Size ~ 250x350nm

Picture taken at: 10Vpp, 1MHz, DI water  
~1.5mS/cm, flow rate ~0.1 ml/min



400x magnification: viral surface lipid membrane labeled green (DiOC63) and viral nucleic acids were stained blue (Hoechst 33342 stain)

# Release voltage vs. diameter for particle collecting the electrode edge, considering the Brownian motion

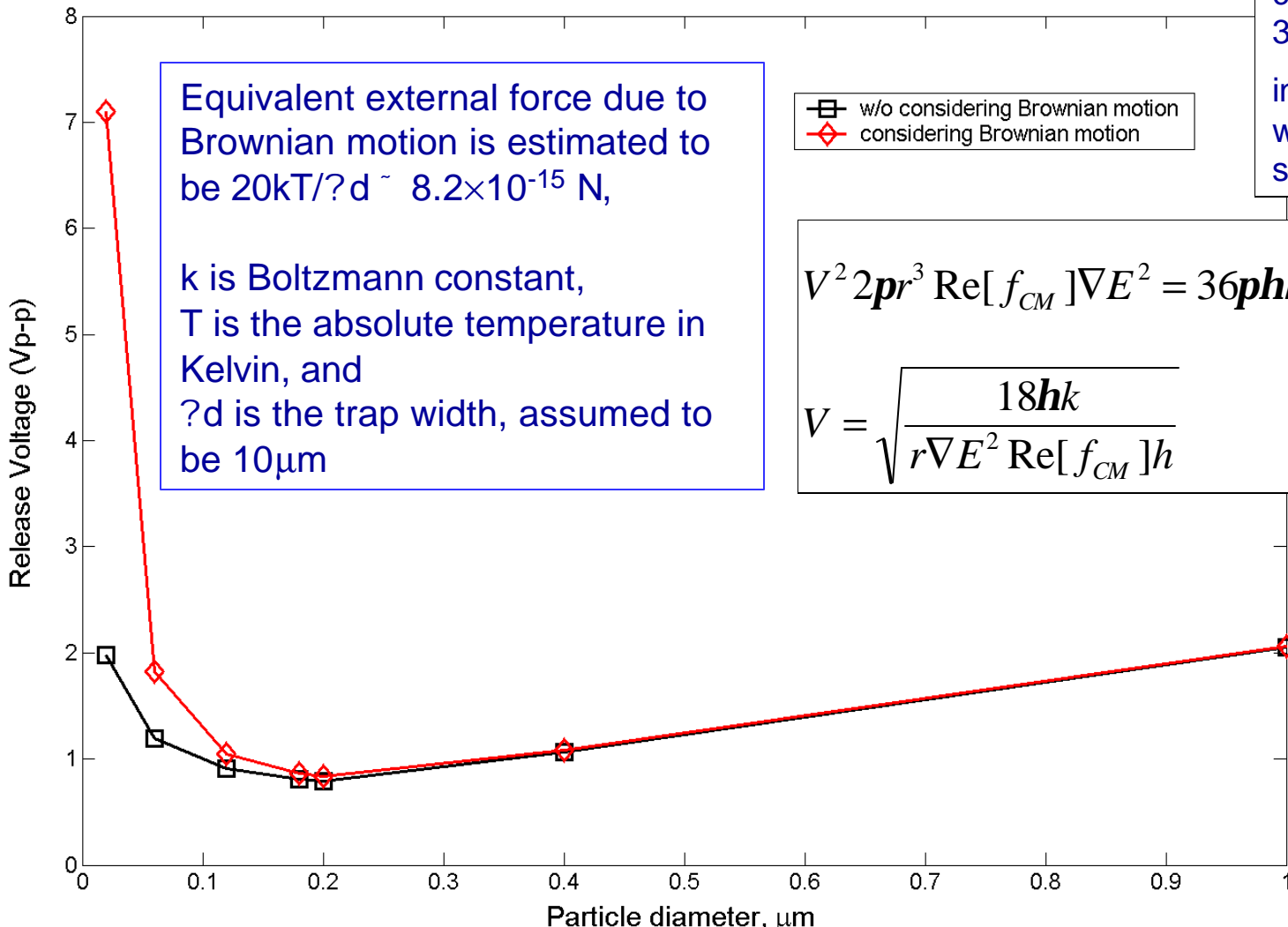
Polarization factor=0.5,  
 flow rate 0.1 μm/min, in the channel with cross-section 350x11.6 μm<sup>2</sup>,  
 interdigitated electrodes with 23 μm width and 17 μm spacing

Equivalent external force due to Brownian motion is estimated to be  $20kT/\delta d \sim 8.2 \times 10^{-15}$  N,  
 k is Boltzmann constant,  
 T is the absolute temperature in Kelvin, and  
 $\delta d$  is the trap width, assumed to be 10 μm

□ w/o considering Brownian motion  
 ◇ considering Brownian motion

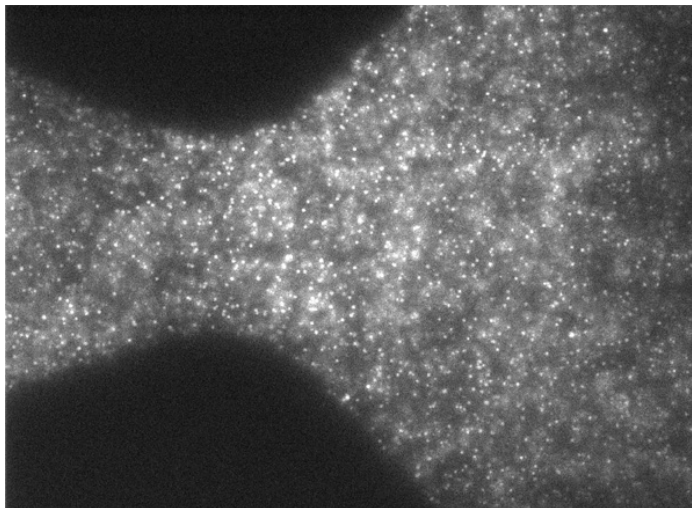
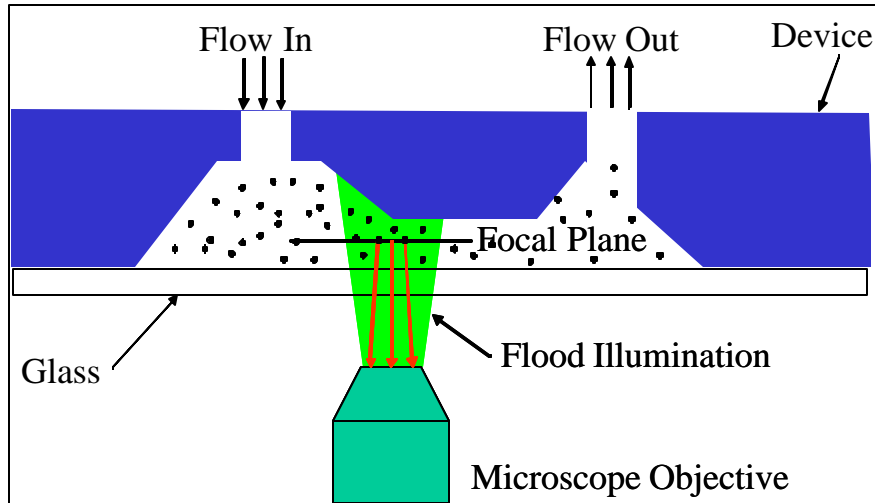
$$V^2 2pr^3 \text{Re}[f_{CM}] \nabla E^2 = 36phkr \left( \frac{r}{h} - \frac{r^2}{h^2} \right) \approx 36phk \frac{r^2}{h}$$

$$V = \sqrt{\frac{18hk}{r \nabla E^2 \text{Re}[f_{CM}] h}}$$

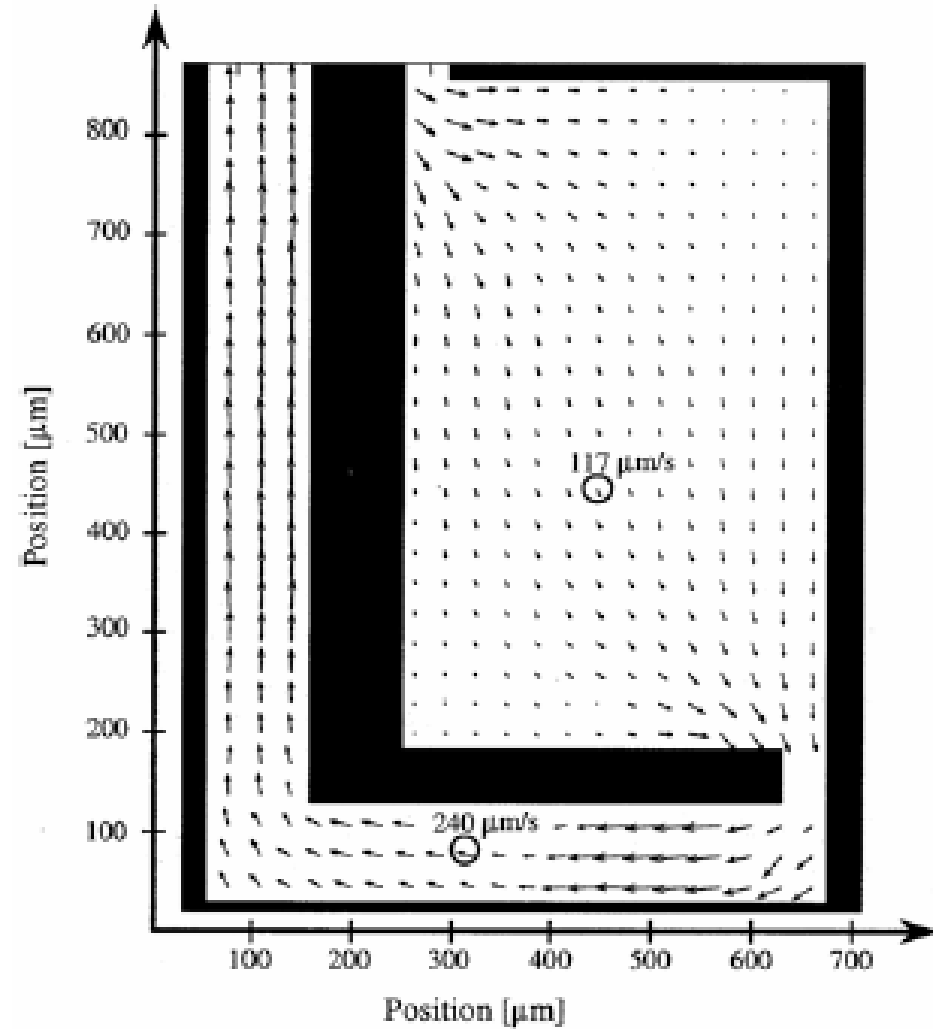


# Micro-fluidic Characterization

- Micro-Particle Imaging Velocimetry ( $\mu$ PIV)



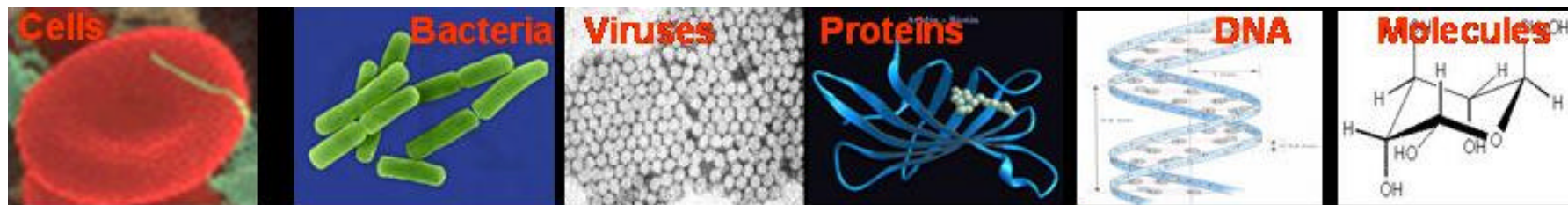
Wereley, et al. Purdue



Gomez, et al. 2001

# Key Topics

- Biochips/Biosensors and Device Fabrication
- Cells, DNA, Proteins
- Micro-fluidics
- **Biochip Sensors & Detection Methods**
- Micro-arrays
- Lab-on-a-chip Devices



# Biochip Sensors

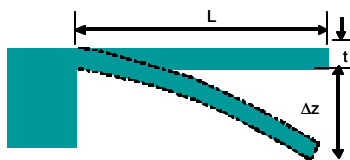
---

- Detect cells (mammalian, plant, etc.), microorganisms (bacteria, etc.), viruses, proteins, DNA, small molecules
- Use optical, electrical, mechanical approaches at the micro and nanoscale in biochip sensors

# Sensing Methods in BioChips

## Mechanical Detection

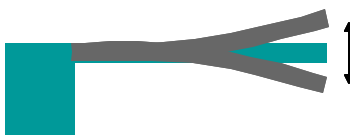
### Surface Stress Change Detection



$$\Delta z = 4 \left( \frac{l}{t} \right)^2 \frac{(1-\nu)}{E} (\Delta s_1 - \Delta s_2)$$

- $\Delta z$  = deflection of the free end of the cantilever
- $L$  = cantilever length
- $t$  = cantilever thickness
- $E$  = Young's modulus
- $\nu$  = poisson's ratio
- $\Delta s_1$  change in surface stress on top surface
- $\Delta s_2$  change in surface stress on bottom surface

### Mass Change Detection



$$f = \frac{1}{2p} \sqrt{\frac{k}{m}}$$

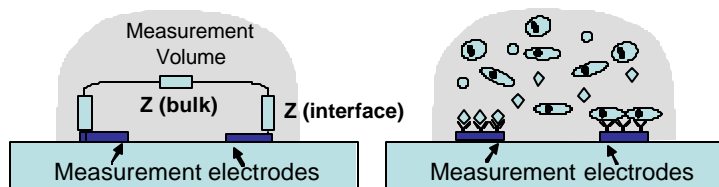
$$\Delta m = \frac{k}{4p^2} \left( \frac{1}{f_1^2} - \frac{1}{f_0^2} \right)$$

- $k$  = spring constant
- $m$  = mass of cantilever
- $f_0$  = unloaded resonant frequency
- $f_1$  = loaded resonant frequency

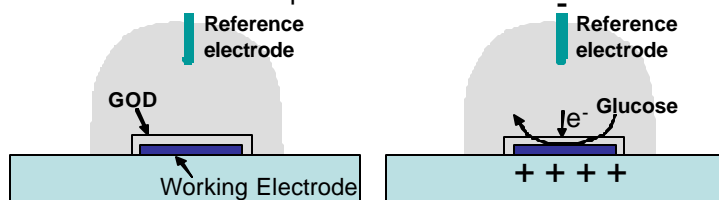
(a)

## Electrical Detection

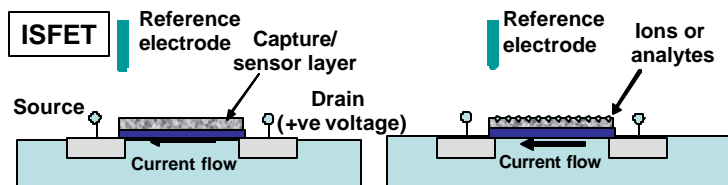
### Conductometric Detection



### Amperometer Detection

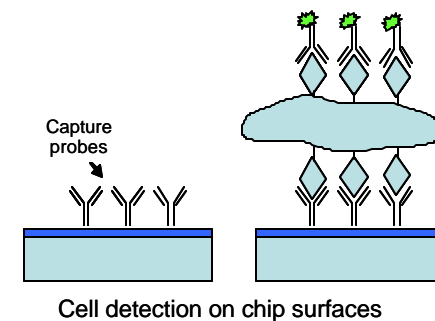
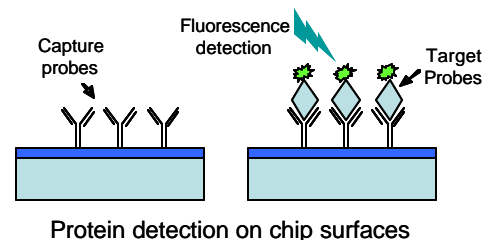
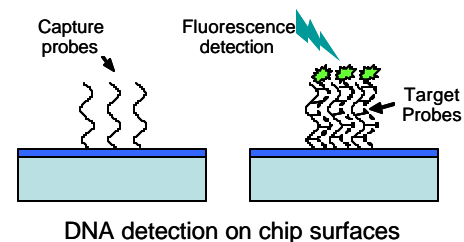


### Potentiometric Detection



(b)

## Optical Detection

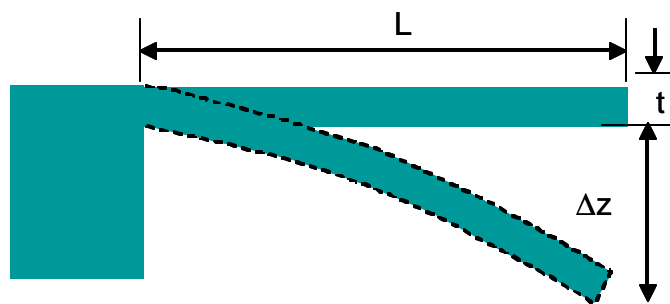


(c)

# 1. Microcantilever Stress Sensors

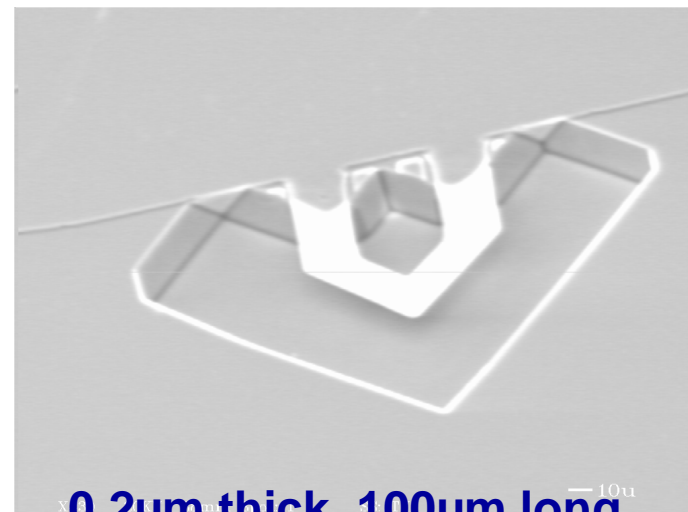
## Mechanical Detection

### Surface Stress Change Detection



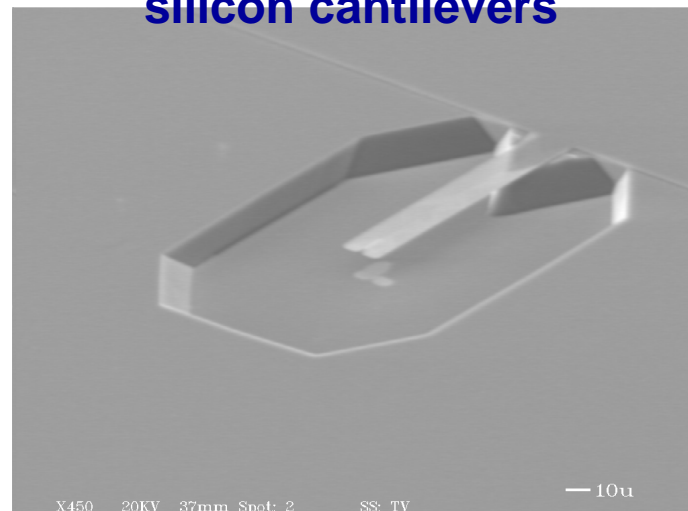
$$\Delta z = 4 \left( \frac{l}{t} \right)^2 \frac{(1-\nu)}{E} (\Delta s_1 - \Delta s_2)$$

- $\Delta z$  = deflection of the free end of the cantilever
- $L$  = cantilever length
- $t$  = cantilever thickness
- $E$  = Young's modulus
- $\nu$  = poisson's ratio
- $\Delta s_1$  change in surface stress on top surface
- $\Delta s_2$  change in surface stress on bottom surface



**0.2μm thick, 100μm long,  
silicon cantilevers**

Title: released after ox etch Date: 07-14-2000 Time: 18:28  
Comment: Filename: 148.TIF

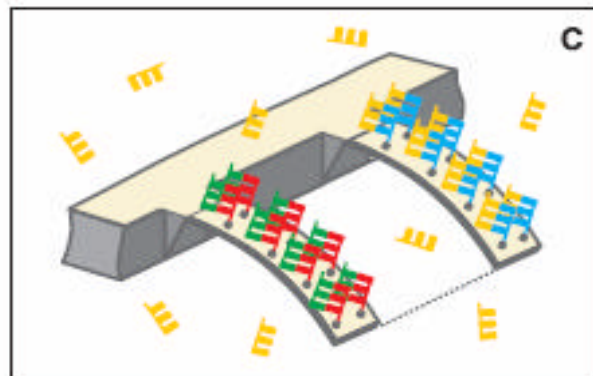
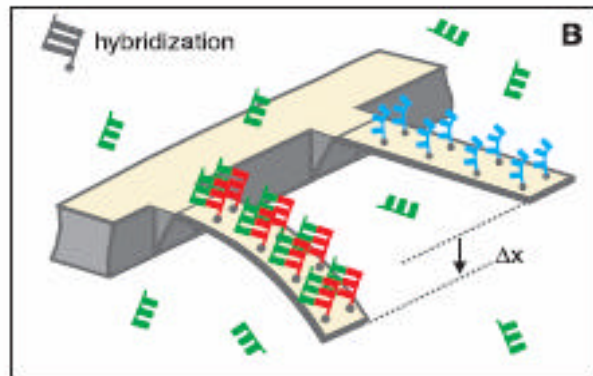
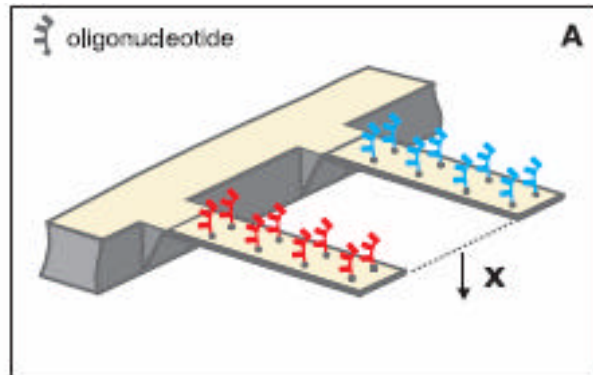


X450 20KV 37mm Spot: 2 SS: TV

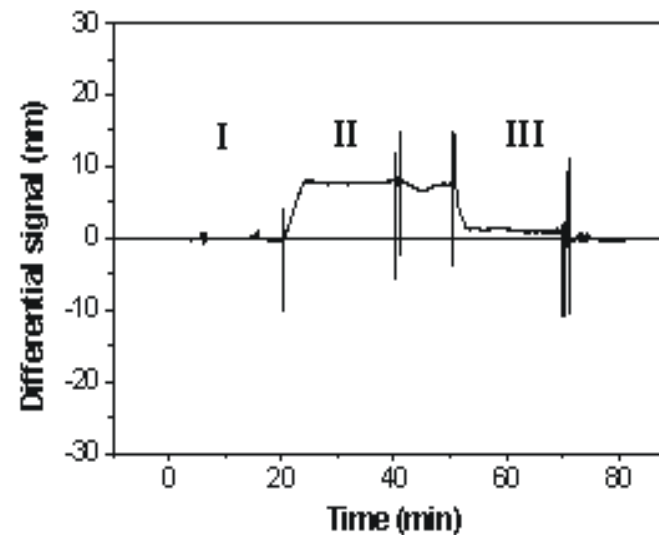
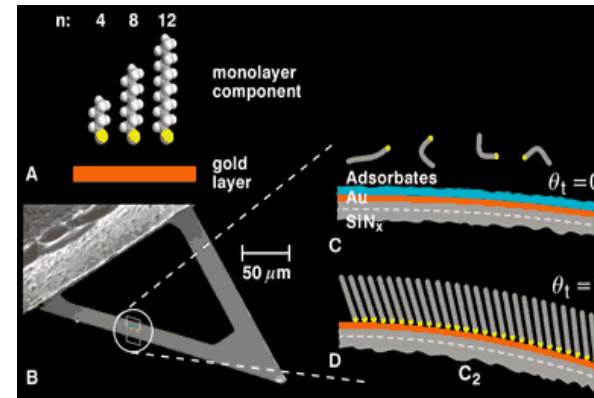
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Comment: Filename: 150.TIF



# Microcantilever Stress Sensors

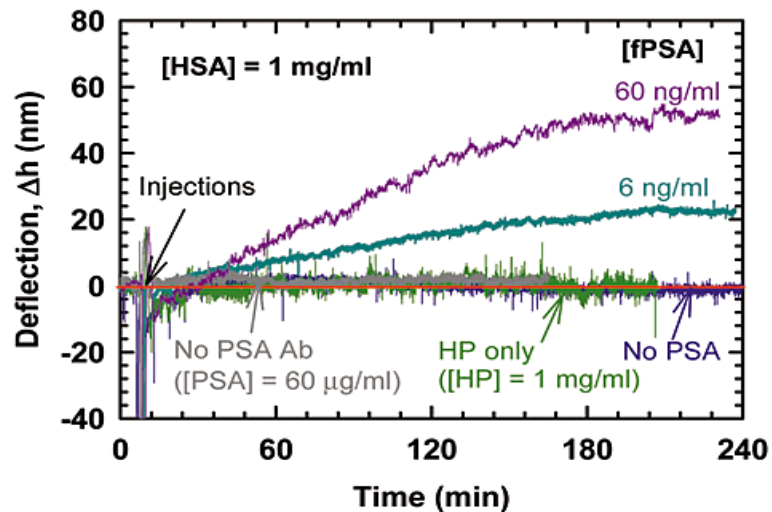
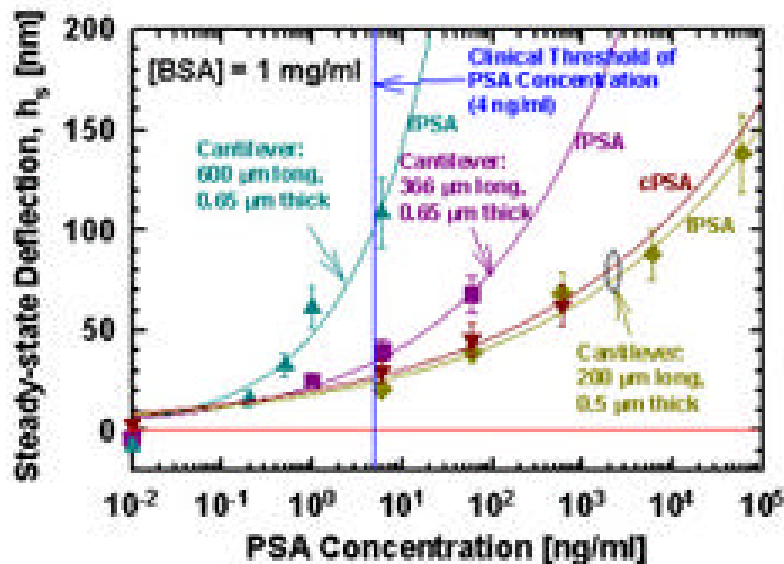
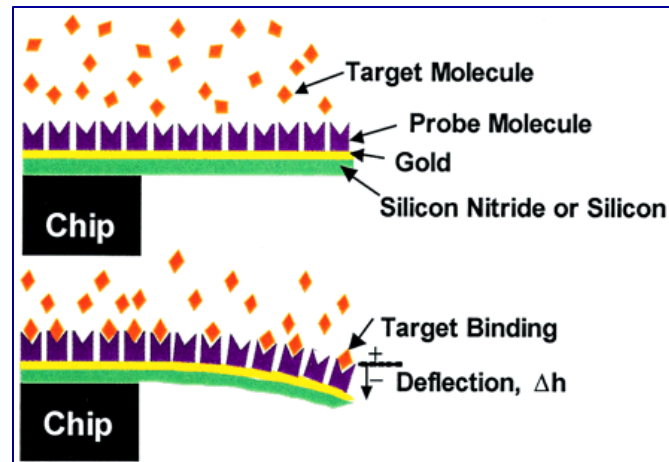


## IBM Zurich Research: DNA Detection



# Microcantilever Stress Sensors

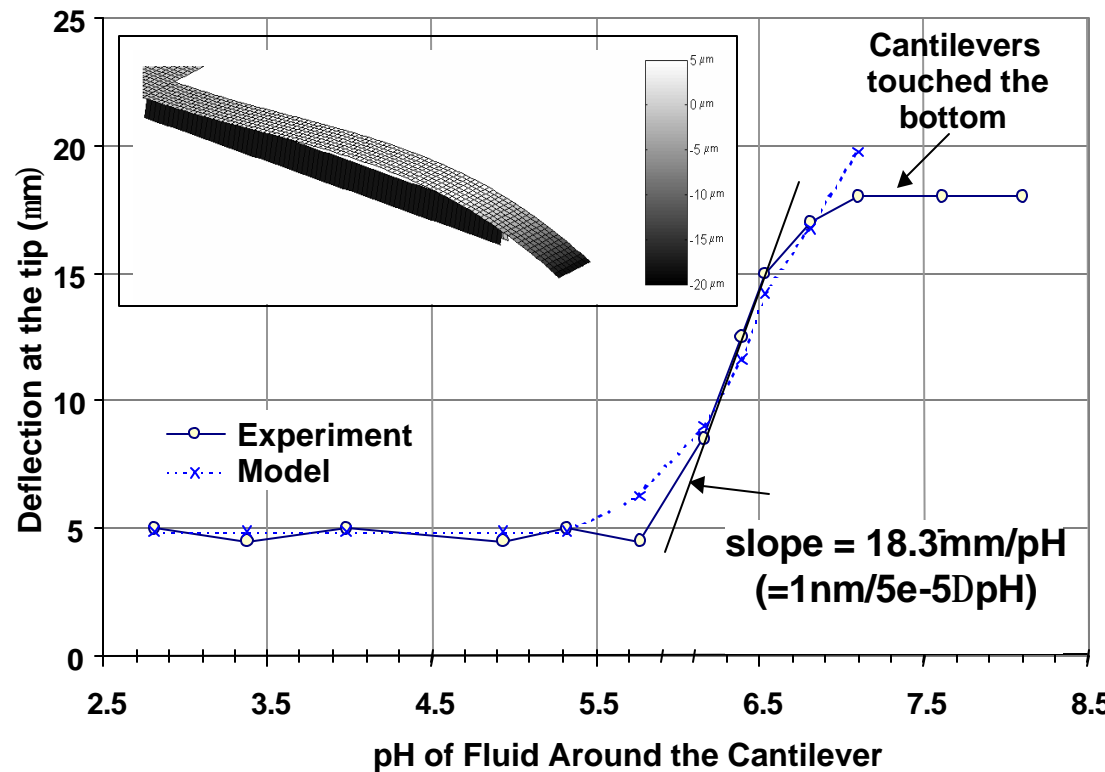
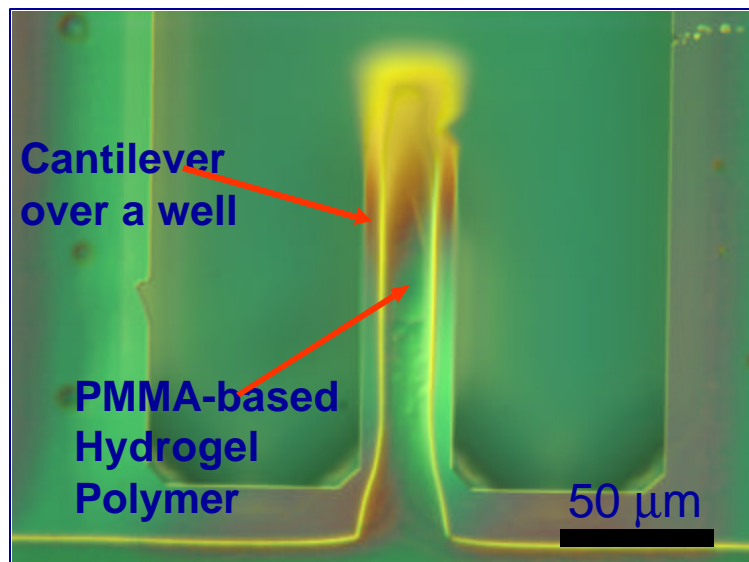
## Detection of PSA, Prostate Specific Antigen (cancer marker protein in blood)



- PSA ~ 30kDa ~  $30 \times 1e3 \times 1.66e-24\text{gm}$
- In 1ng/ml ~  $2e10$  molecules/ml
- Area of 20 $\mu\text{m}$  x 60 $\mu\text{m}$ , each protein 10nm x 10nm  $\rightarrow$   $\sim 1e8$  proteins

# Polymer/Silicon Cantilever Sensors

- Environmentally sensitive micro-patterned polymer structures on cantilevers
- Hydrogel patterned on cantilever and then exposed to varying pH



- $\Delta\text{pH} = 1-10\text{e-}5$
- $\text{pH} = 6.5 \rightarrow \sim 1.9\text{e}5 \text{ H}^+$  in  $1000\text{mm}^3$
- $\Delta\text{pH} = 5\text{e-}4 \rightarrow$  change of  $\sim 150 \text{ H}^+$

# 2. Microcantilever Mass Sensors

Unloaded Resonant Frequency :

$$f_0 = \frac{1}{2\pi} \sqrt{\frac{k}{m^*}}$$

Spring constant for a rectangular shaped cantilever beam:  $k = \frac{Et^3w}{4l^3}$

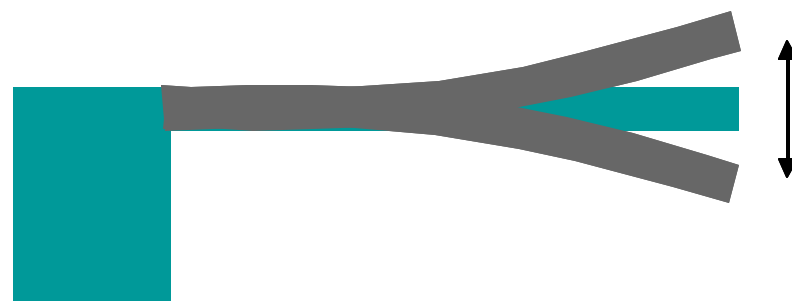
Loaded Resonant frequency :  $f_1 = \frac{1}{2\pi} \sqrt{\frac{k}{m^* + dm}}$

$\delta m$  is the added mass

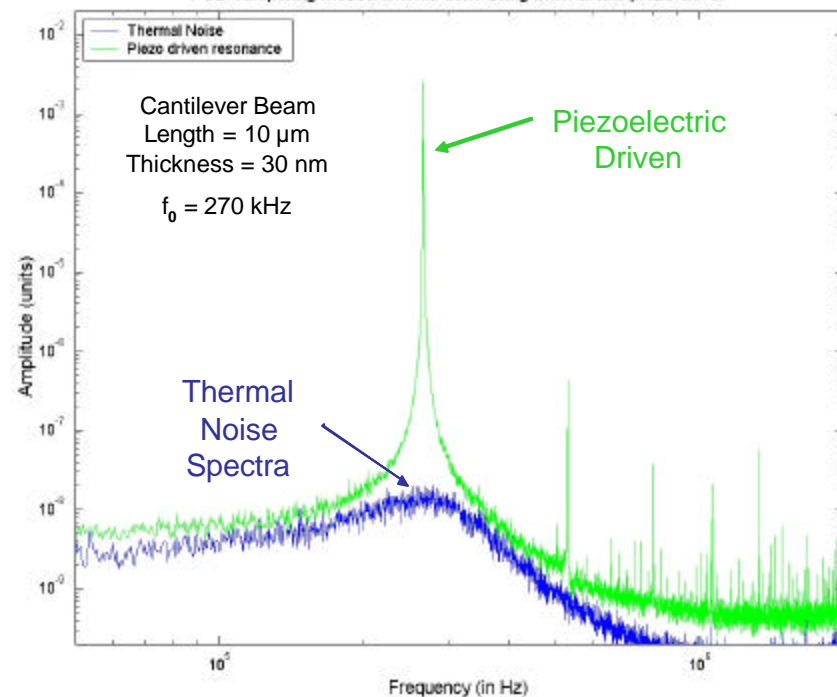
$$\Delta m = \frac{k}{4\pi^2} \left( \frac{1}{f_1^2} - \frac{1}{f_0^2} \right)$$

- $k$  = spring constant
- $m$  = mass of cantilever
- $f_0$  = *unloaded resonant frequency*
- $f_1$  = *loaded resonant frequency*

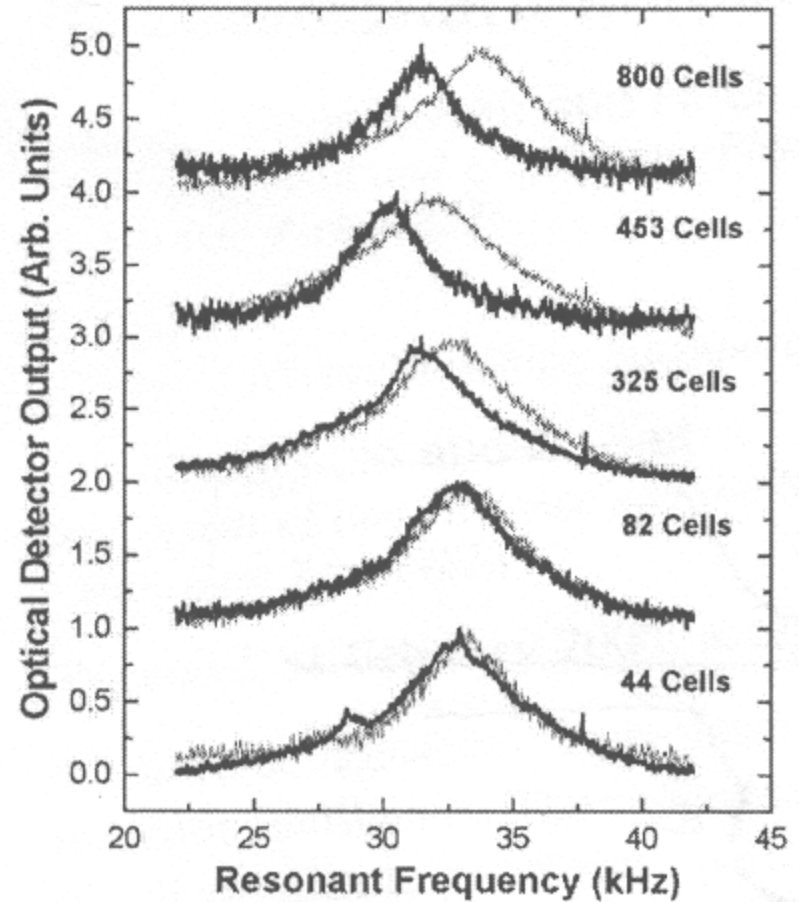
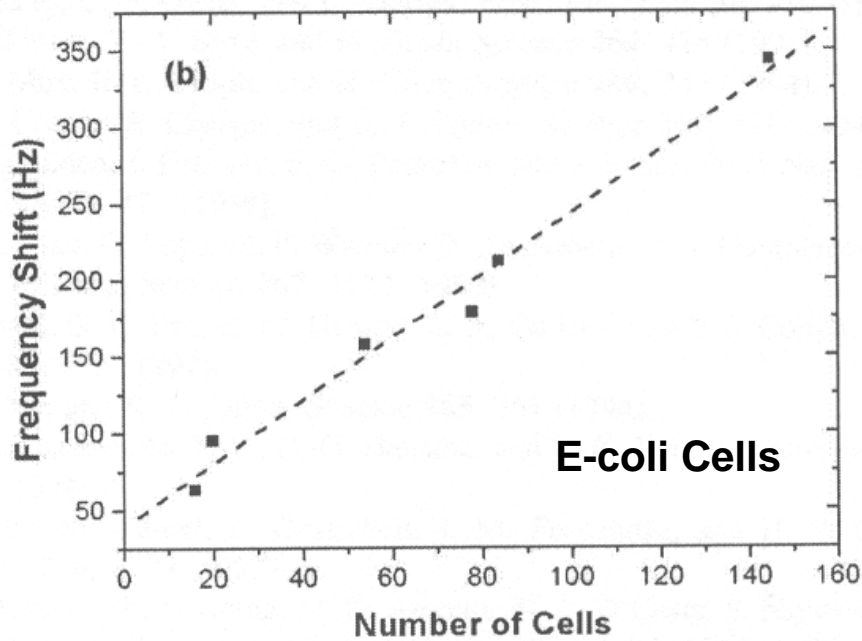
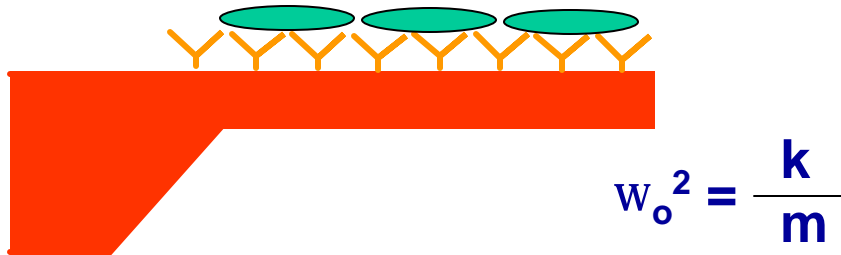
## Mass Change Detection



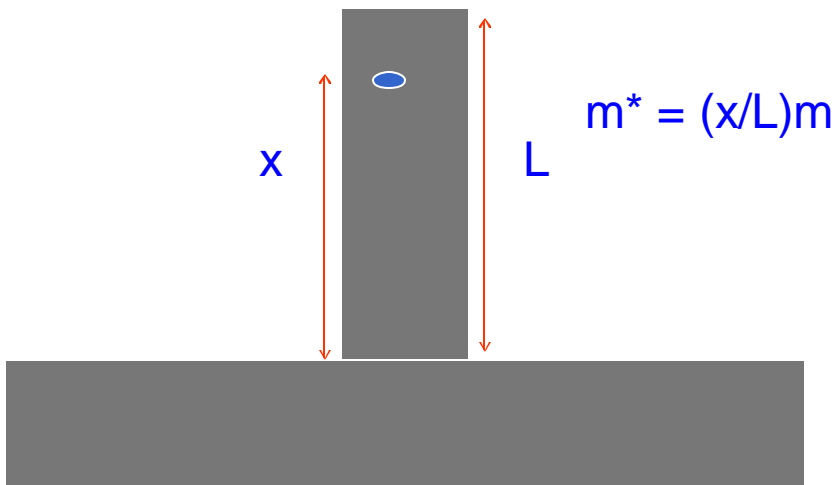
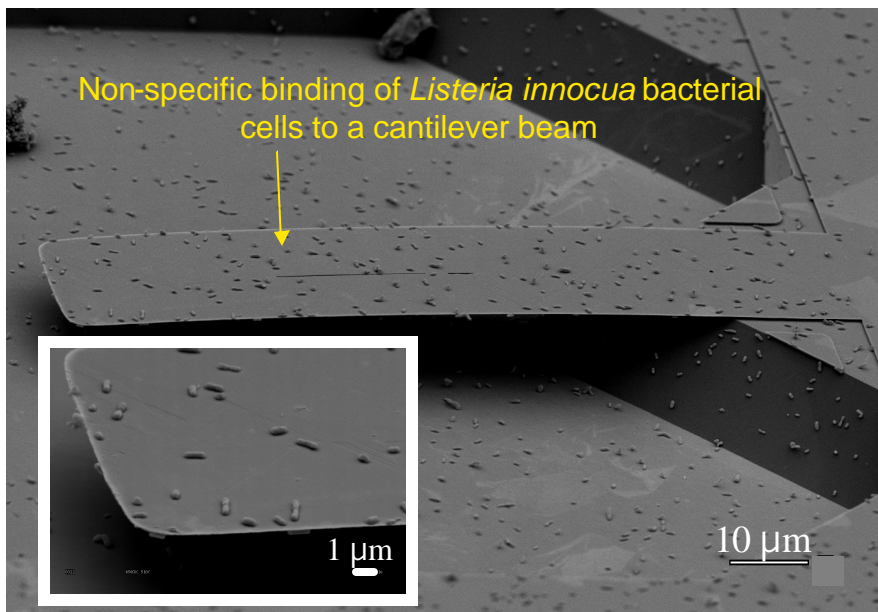
PSD comparing measurements done using thermal and piezo driven



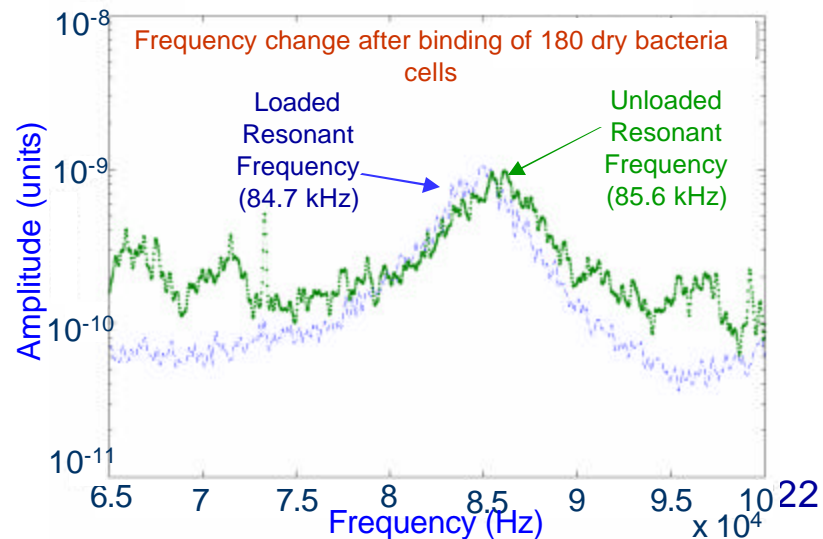
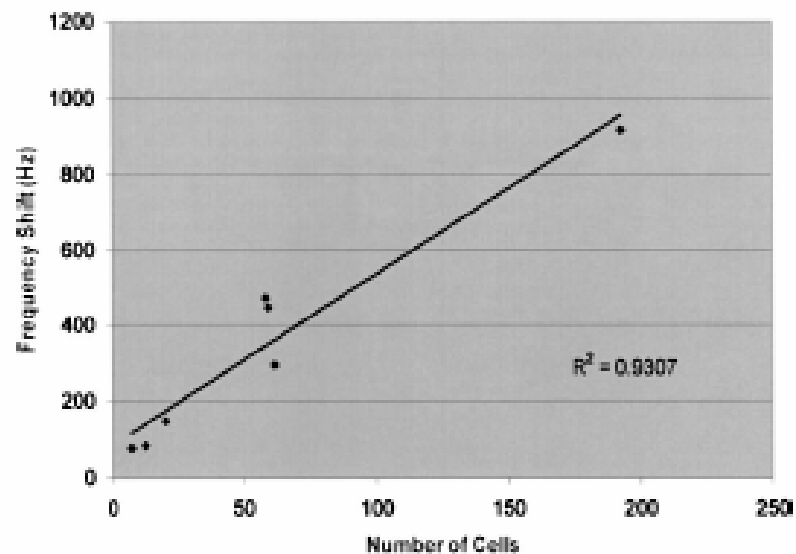
# Detection of Bacterial Mass



# Detection of Listeria Cell Mass



Frequency Shift vs. No. of Cells



# Minimum Detectable Mass

- The frequency measurement is limited by thermo-mechanical noise on the cantilever beam.

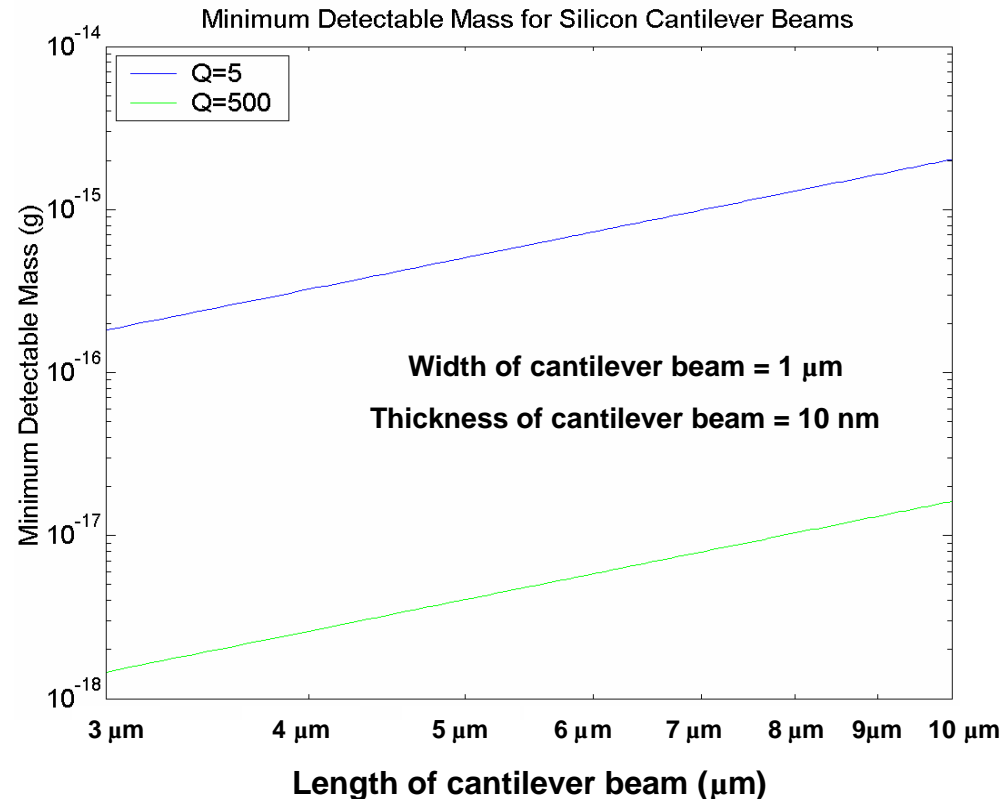
- Minimum Detectable Frequency,  $f_{\min}$  =

$$\frac{1}{A} \sqrt{\frac{f_0 k_B T B}{2 p k Q}}$$

- Minimum Detectable Mass,  $m_{\min}$  =

$$\frac{1}{A} \sqrt{\frac{4 k_B T B}{Q}} \frac{m_{\text{eff}}^{5/4}}{k^{3/4}}$$




- $k_B$  = Boltzmann constant
- T = Temperature in Kelvin
- B = Bandwidth measurement, (~ 1 kHz)
- Q can increase by 100X by driving the cantilevers



Roukes, et al.

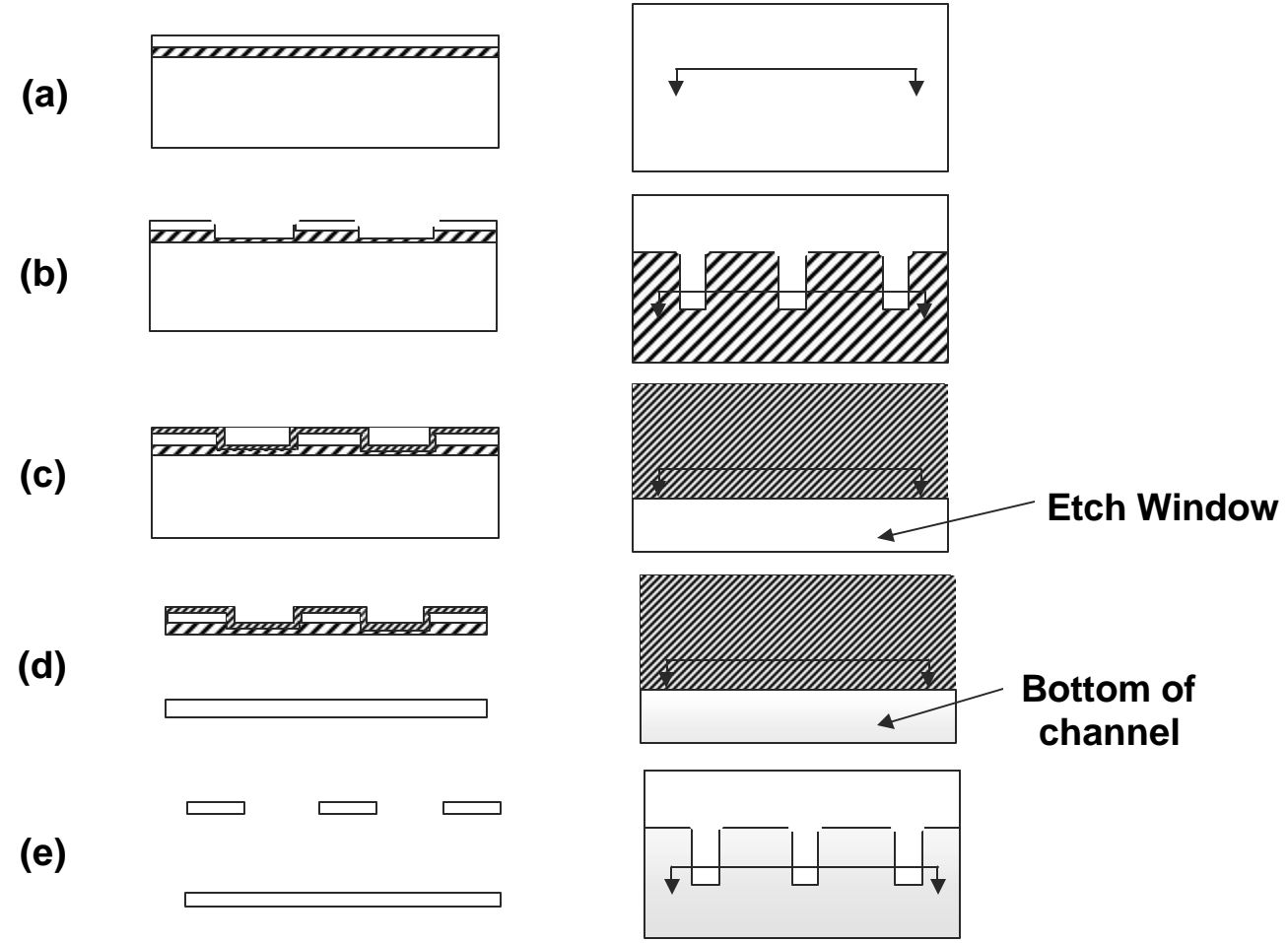
# Fabrication Process Flow

## Materials Legend

-  Silicon
-  Silicon dioxide
-  PECVD Silicon dioxide

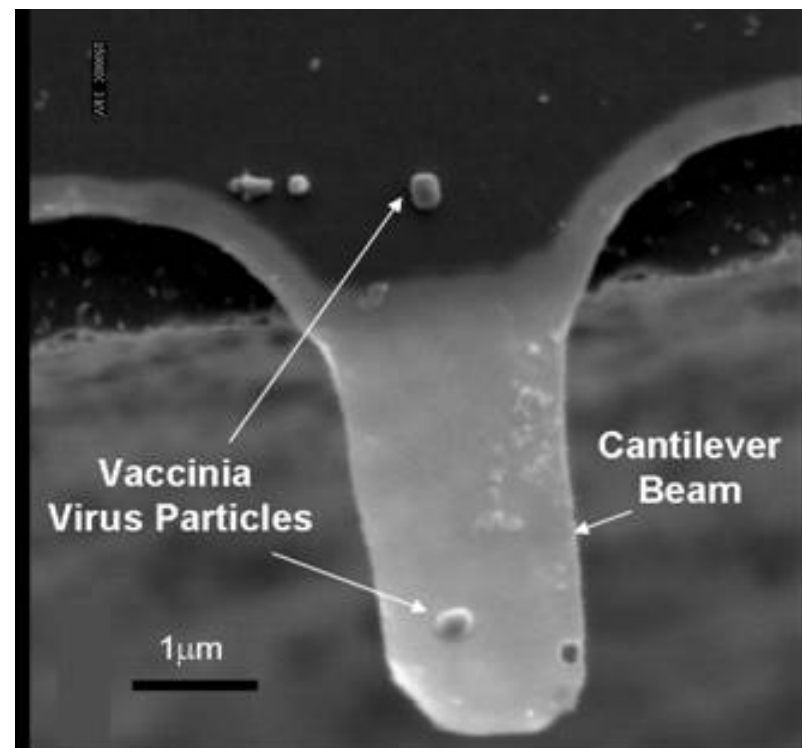
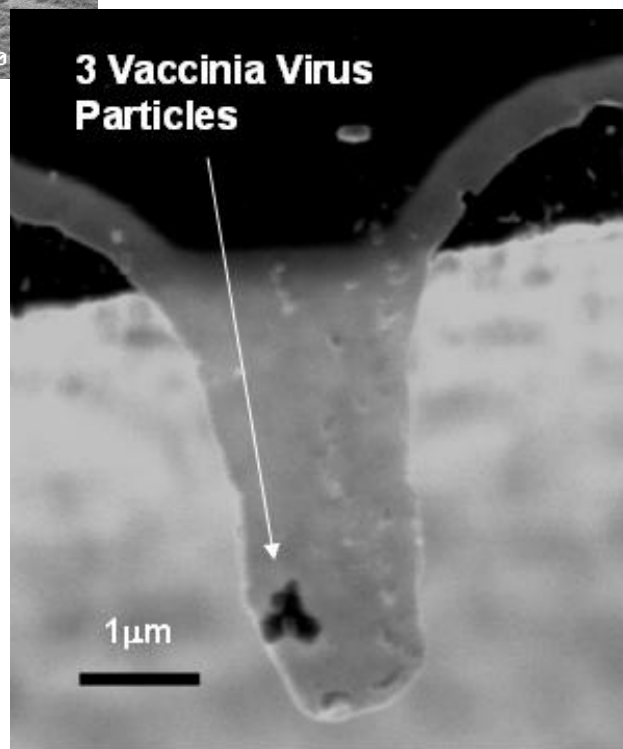
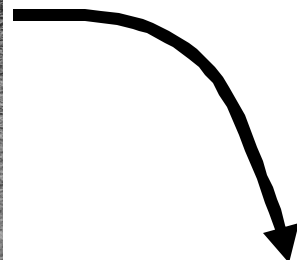
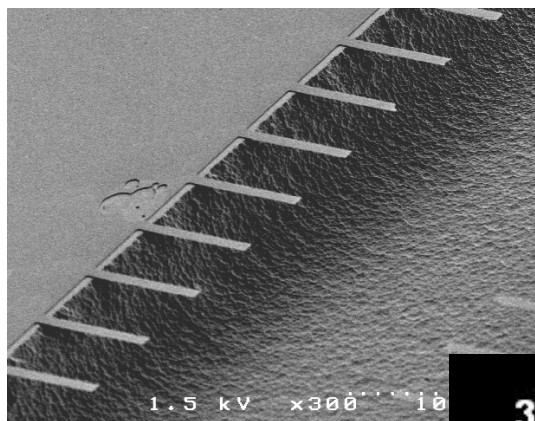
Cross-sectional view

Top view

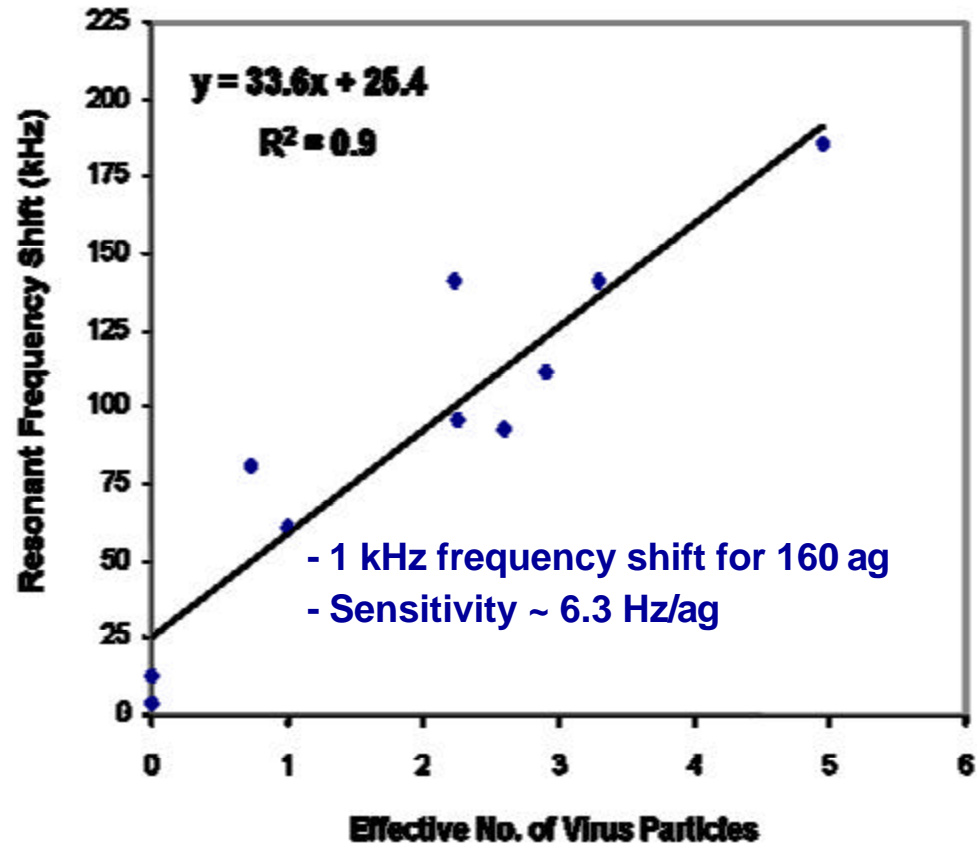
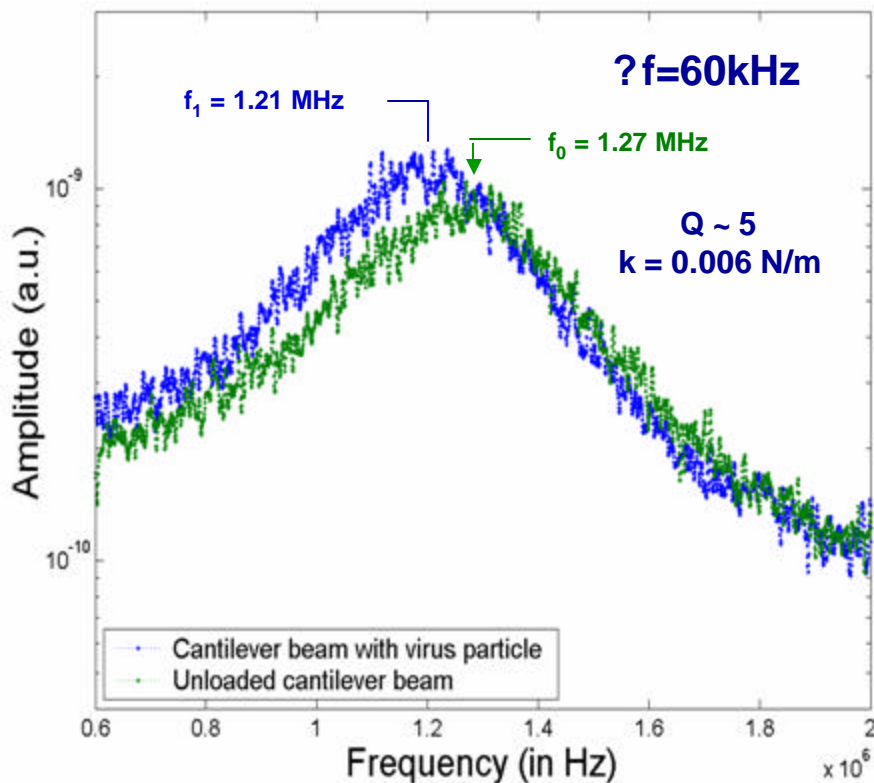




# SEM Pictures of Cantilevers

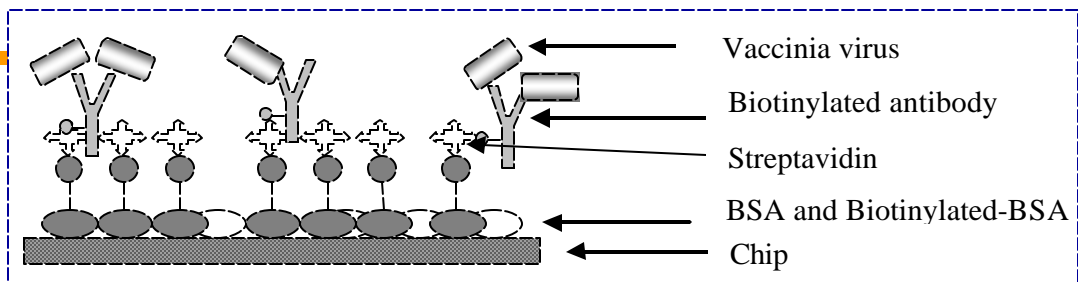


# Frequency Shift vs. No. of Particles

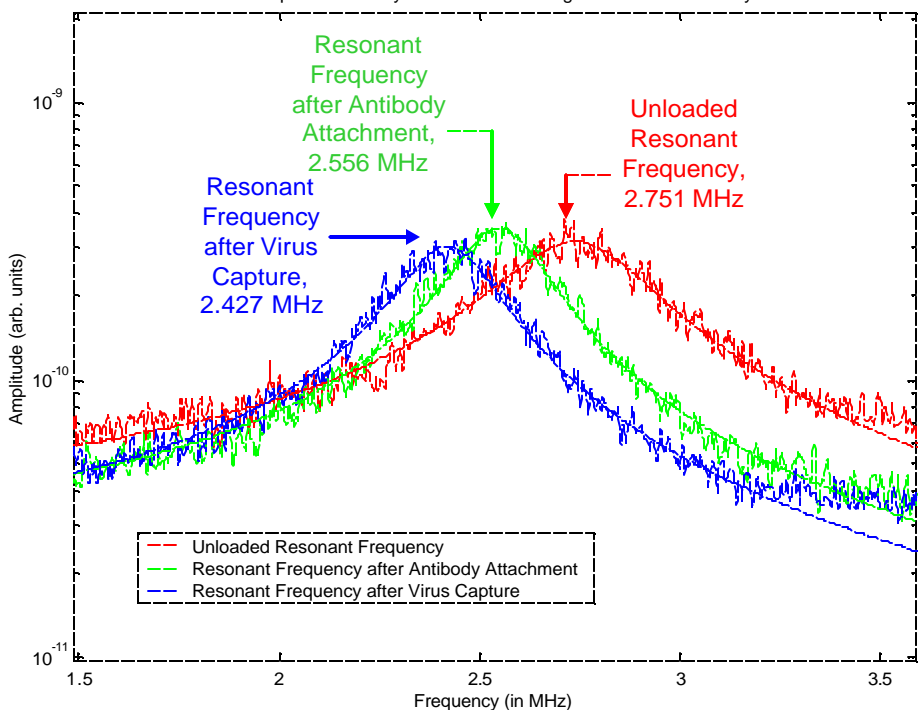


- Average mass of Vaccinia Virus  $\sim 9.5$ fg
- Work on going to integrated concentration elements
- Integrated Abs on cantilevers

# Specific Capture of Virus Particles

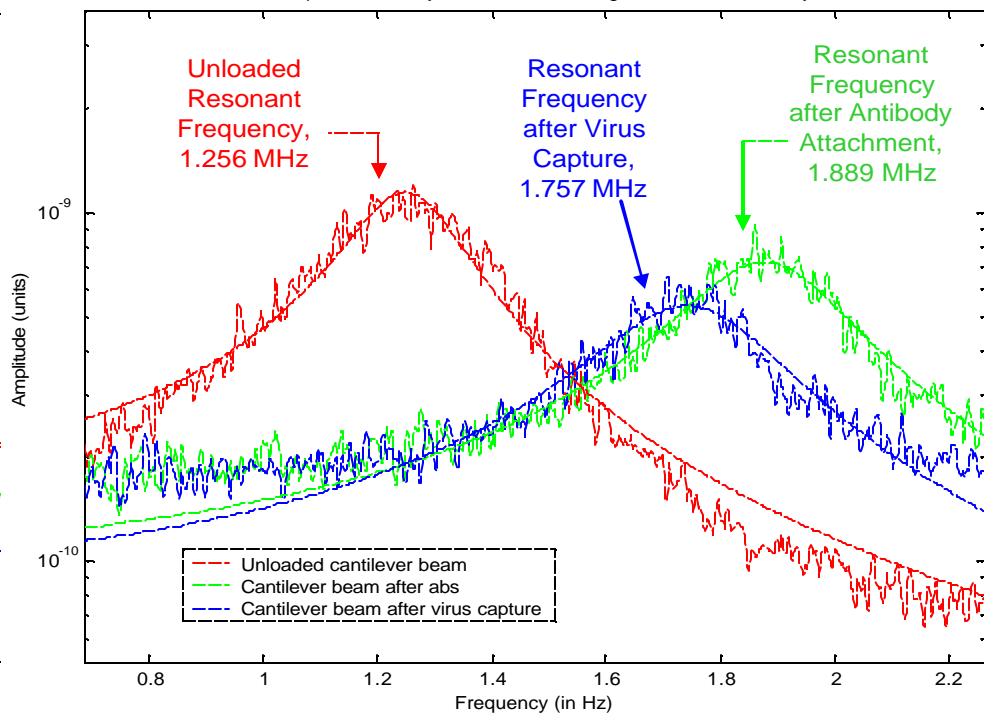


Power Spectral Density Plot at Various Stages of Biosensor Analysis



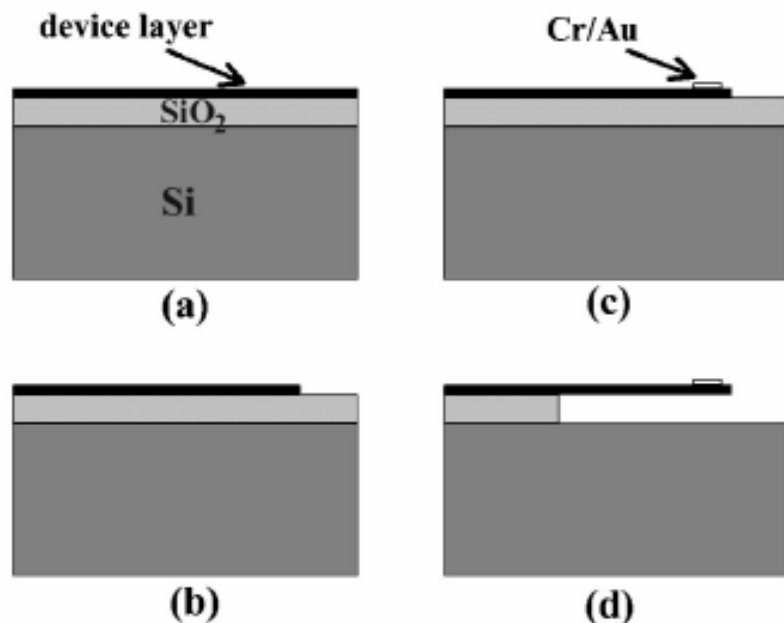
**Virus capture experiment:  $\omega_0$  decreases with Ab attachment and with antigen capture**

Power Spectral Density Plot at Various Stages of Biosensor Analysis



**Virus capture experiment:  $\omega_0$  increases with Ab attachment and decreases with antigen capture**

# Mass of Molecules



To probe the amount of thiolate binding to the Au contacts, we have measured the frequency spectra before and after the thiolate self-assembly. Figure 14 shows the measured shift in the resonant frequency for DNP-PEG4-C11thiol binding on 50- and 400-nm-diam Au contacts. The measured frequency shifts were 125 Hz and 1.10 kHz, corresponding to calculated masses of 6.3 and 213.1 ag, respectively.

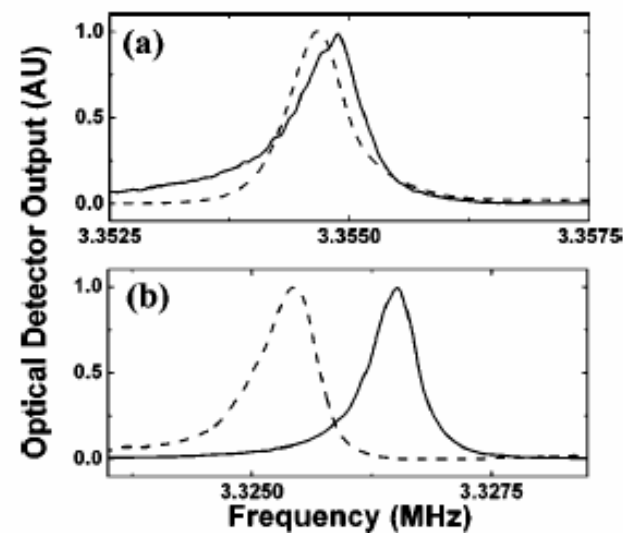
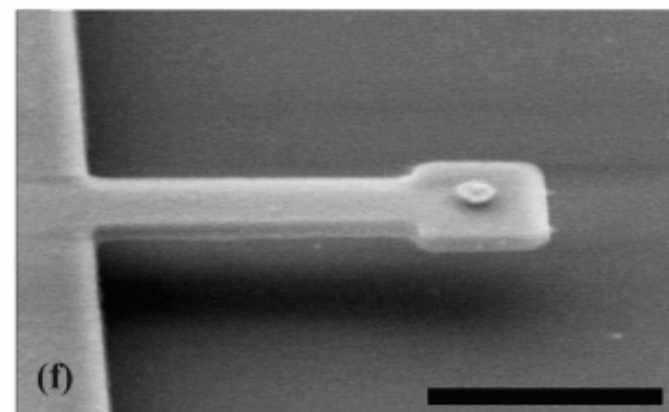


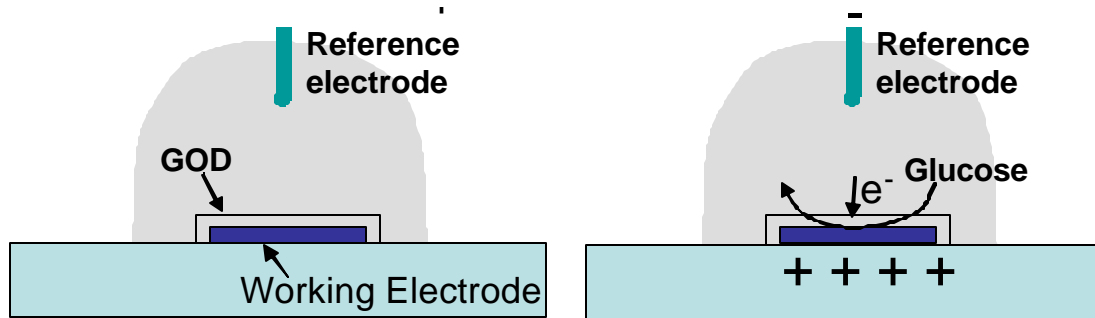
FIG. 14. Experimentally measured frequency spectra before (solid line) and after (dashed line) the adsorption of the thiolate on (a) 50- and (b) 400-nm-diam Au contact. Rectangular beam dimensions were  $l=10\ \mu\text{m}$ ,  $w=1\ \mu\text{m}$ , and  $t=250\ \text{nm}$ .

# Electrical/Electrochemical Detection

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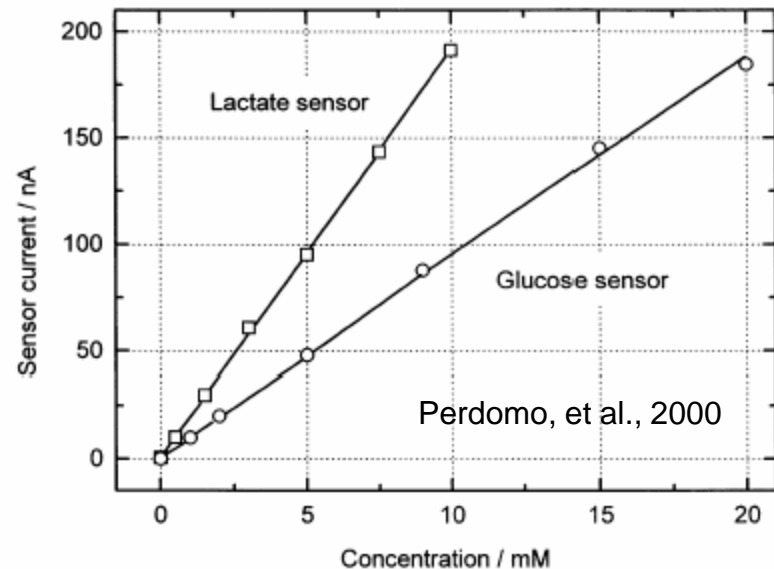
1. amperometric biochips, which involves the electric current associated with the electrons involved in redox processes,
2. potentiometric biochips, which measure a change in potential at electrodes due to ions or chemical reactions at an electrode (such as an ion Sensitive FET), and
3. conductometric biochips, which measure conductance changes associated with changes in the overall ionic medium between the two electrodes.

# 1. Amperometric Detection



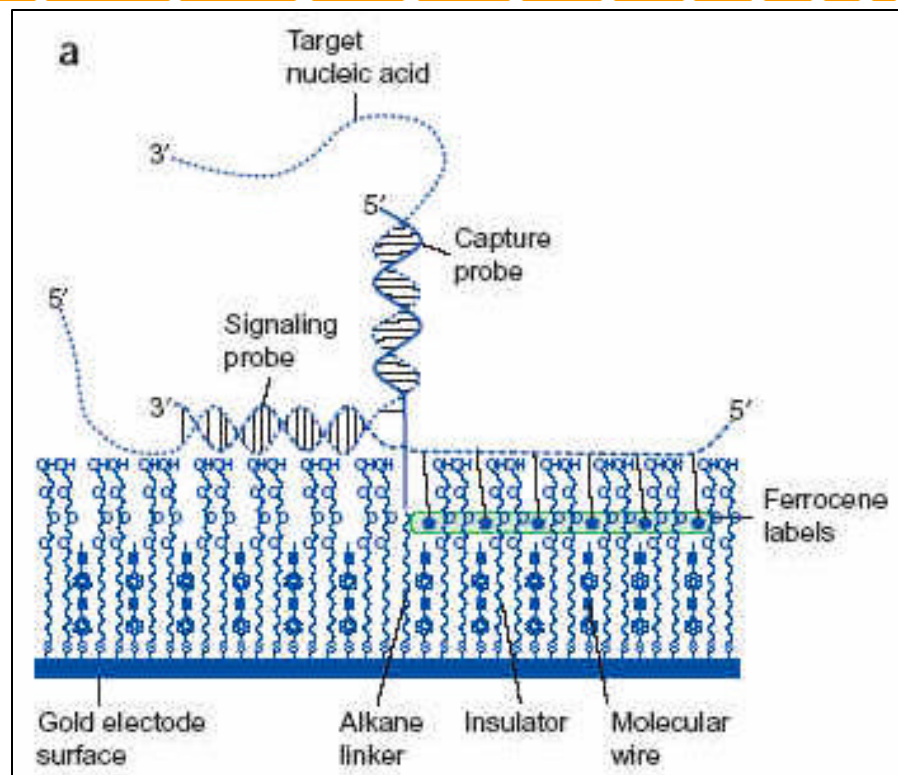
hydrogen peroxide is reduced at -600mV at Ag/AgCl anode reference electrode.

- Detection of Glucose, Lactate, Urea, etc.
- Enzyme entrapped in a gel
- Surface regeneration and sensor reusability



# Detection of DNA Hybridization

- Capture probes are attached to electrodes.
- Target DNA binds to complementary probes
- DNA sequences, called signaling probes, with electronic labels attach to them (ferrocene-modified DNA oligonucleotides,  $E_{1/2}$  of 0.120 V vs. Ag/AgCl, act as signaling probes).
- Binding of the target sequence to both the capture probe and the signaling probe connects the electronic labels to the surface.
- The labels transfer electrons to the electrode surface, producing a characteristic signal.

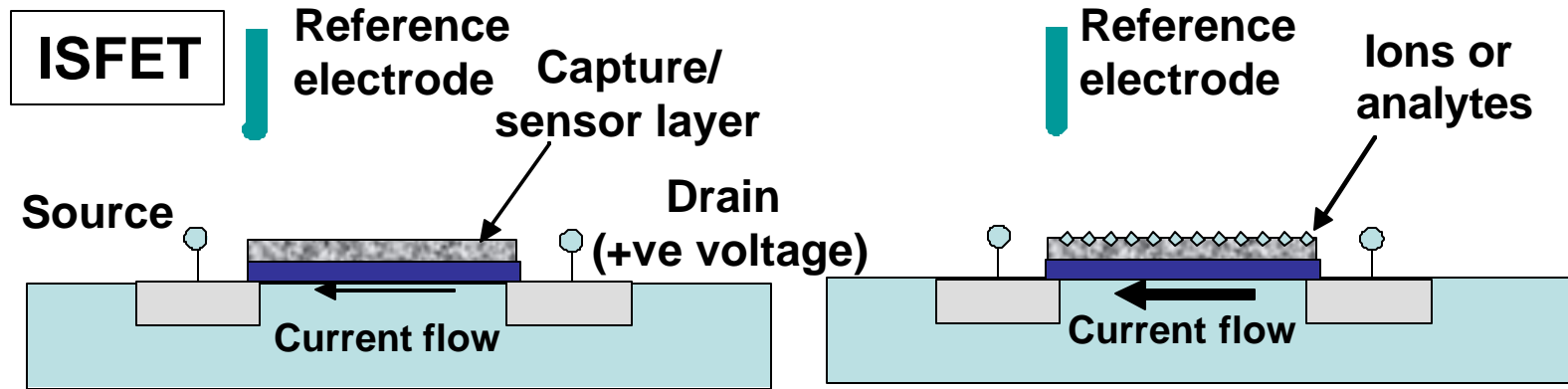


Umek, et al. J. Molecular Diagnostics, 3, 74-84, 2001

Drummond, Hill, Barton, Nature Biotech, v21, n10, Oct 2003, p1192

[http://www.motorola.com/lifesciences/esensor/tech\\_bioelectronics.html](http://www.motorola.com/lifesciences/esensor/tech_bioelectronics.html)

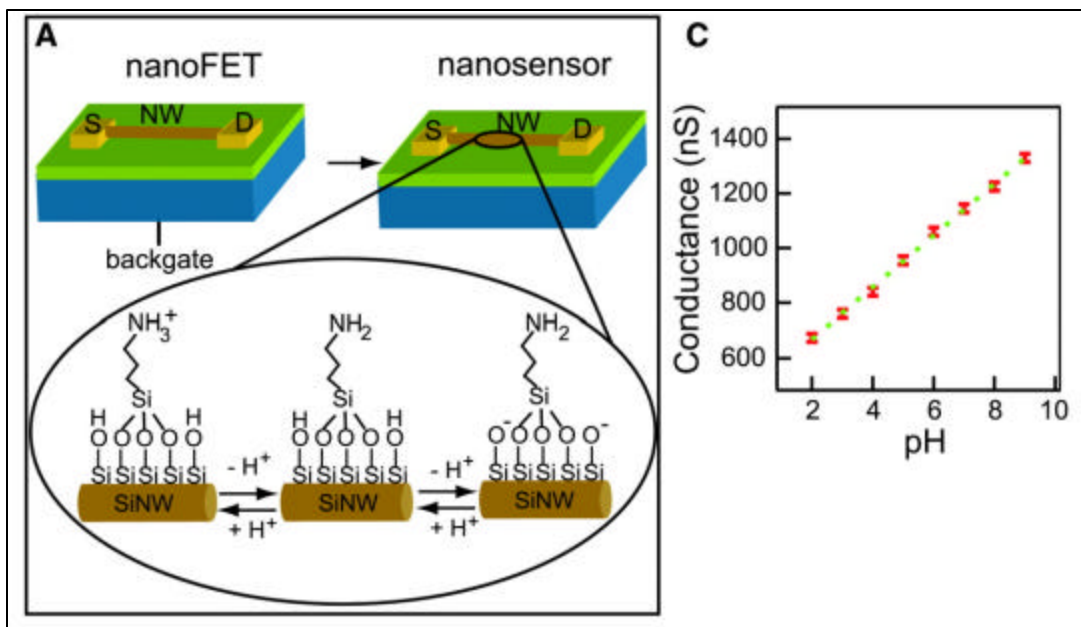
## 2. Potentiometric Sensors



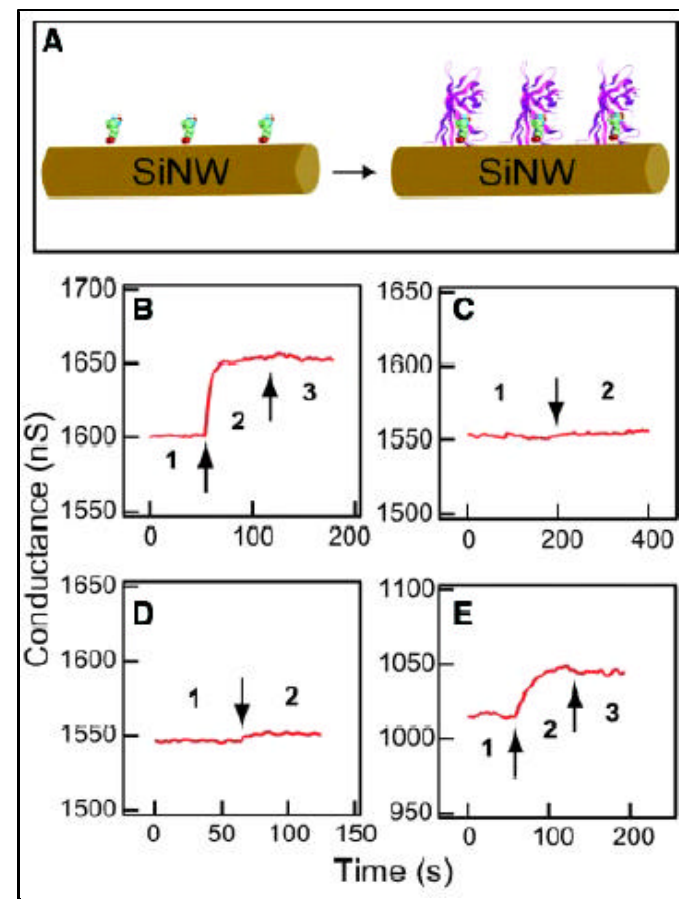
- ISFETs, ChemFETs, etc.
- Potential difference between the gate and the reference electrode in the solution
- Change in potential converted to a change in current by a FET or to a change in capacitance in low doped silicon
- Gate material is sensitive to specific targets
- pH, Ions, Charges



# Nanoscale pH Sensors



- Label Free !!
- Detection of pH change
- Detection of protein binding

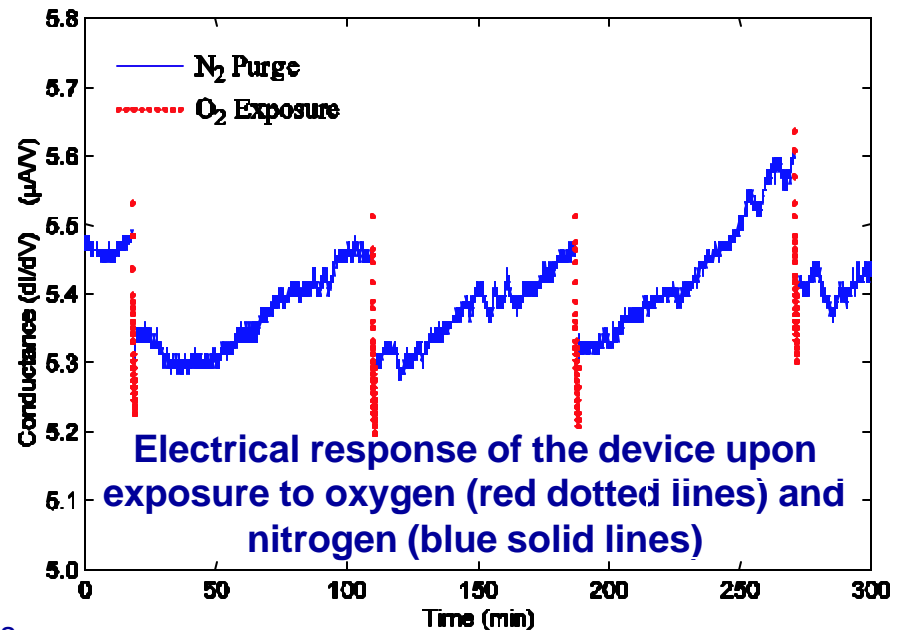
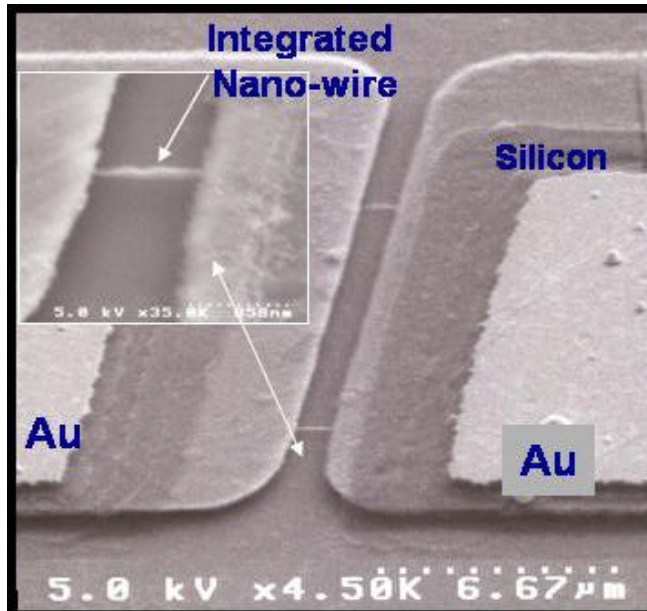
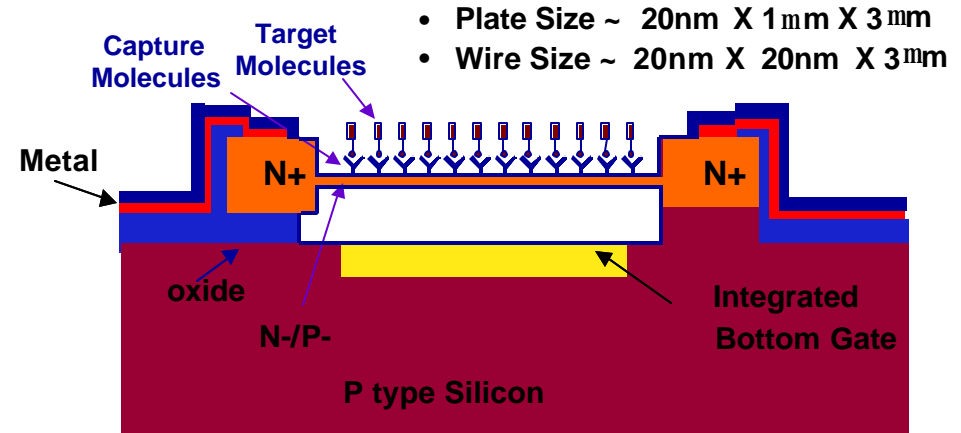


- Streptavidin binding detection down to at least **10 pM**.
- Substantially lower than the nanomolar range demonstrated by other procedures.

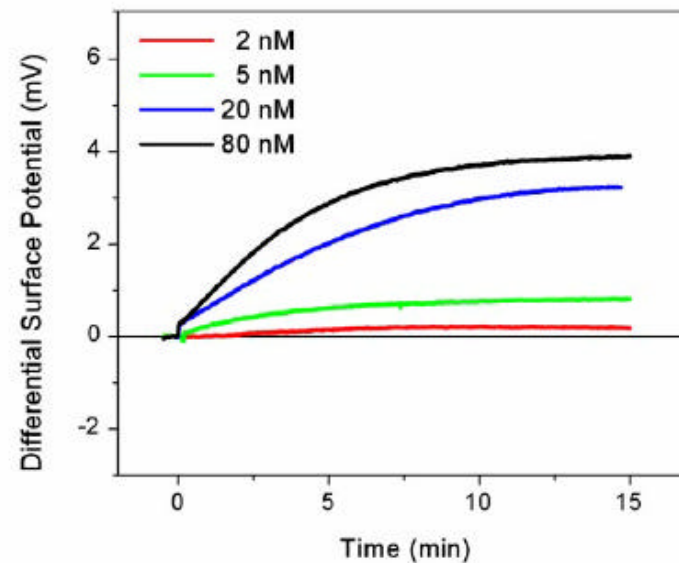
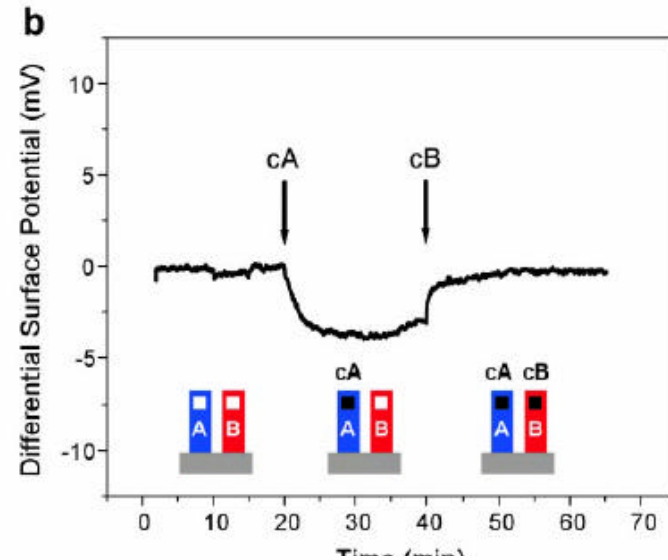
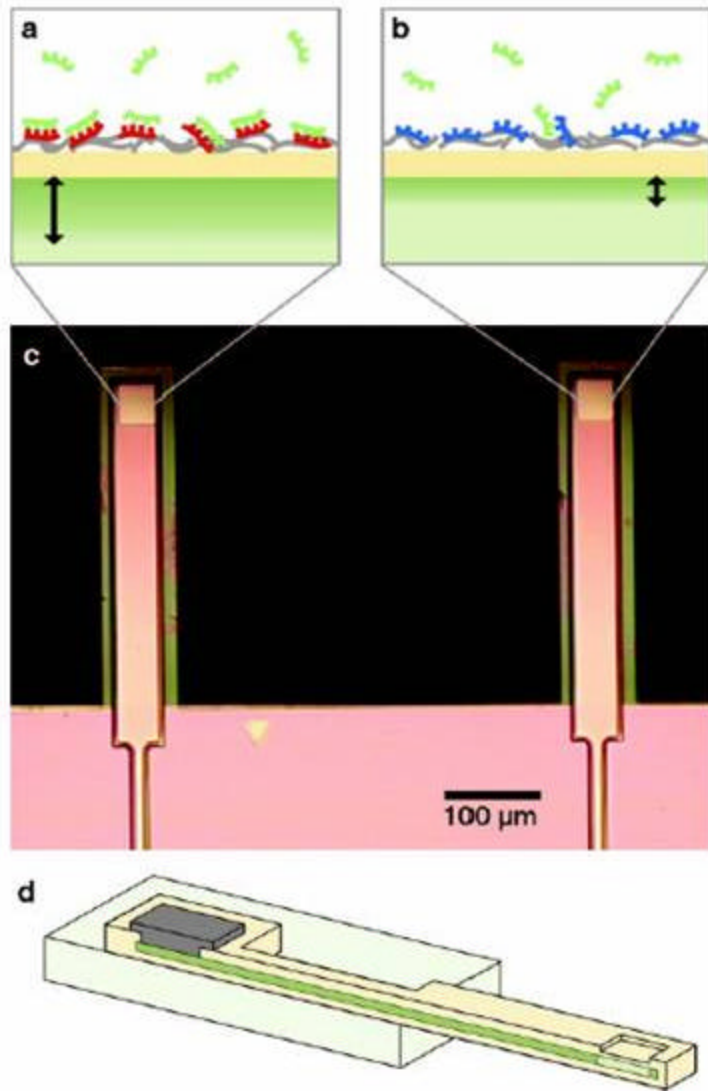
# Integrated Silicon Nanowire Sensors

## Objectives:

- Bio-sensors with electronic output
- Capability of dense arrays integrated with ULSI silicon
- Direct Label Free Detection of DNA and Proteins

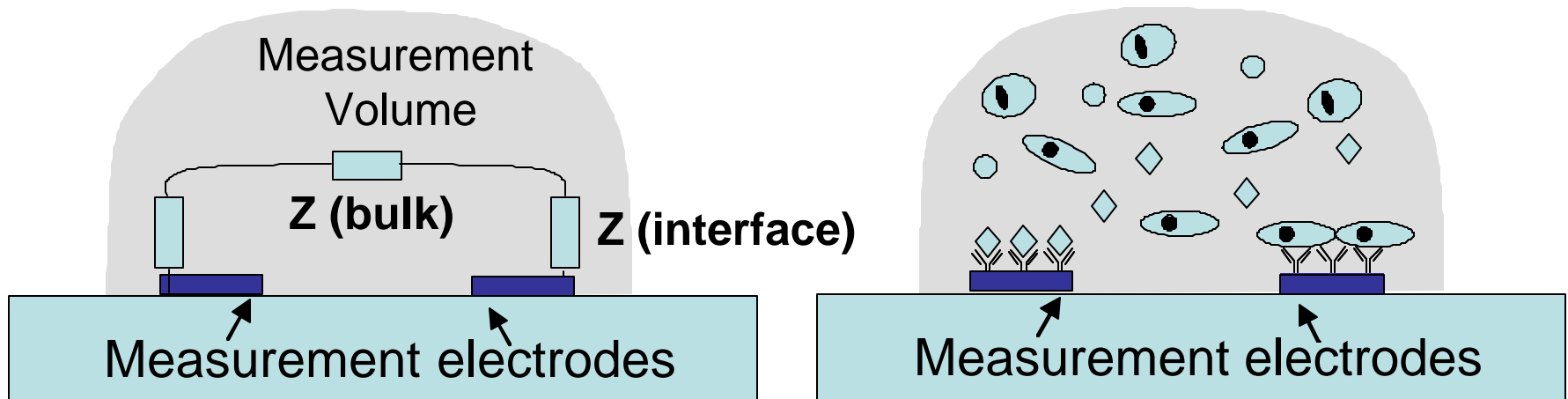


# Field Effect Sensing of DNA



# 3. Conductometric Biochips

- Conductometric sensors measure the changes in the electrical impedance between two electrodes, where the changes can be at an interface or in the bulk region and can be used to indicate biomolecular reaction between DNA, Proteins, and antigen/antibody reaction, or excretion of cellular metabolic products.



# Nanoparticle Mediated DNA Detection

- Au nanoparticles assemble between two electrodes if DNA is hybridized
- Silver staining of the Au nanoparticles
- Conductance changes between micro-scale electrodes indicate DNA hybridization
- Sensitivity of  $5 \times 10^{-13}$  M shown

